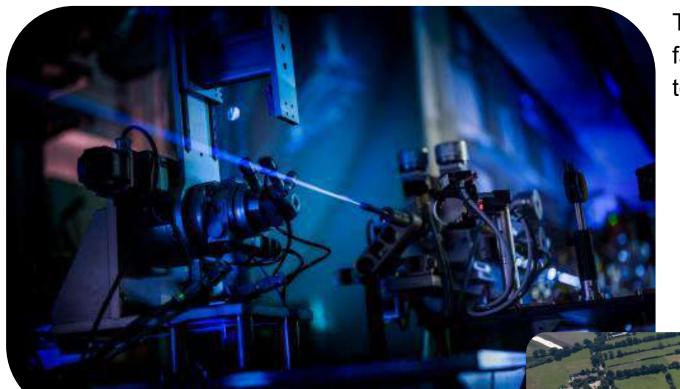
# **European XFEL Enlightening Science**

Antonio Bonucci Head of Industrial Liaison Office and In-kind Contributions Supply Chain

antonio.bonucci@xfel.eu



## European XFEL—a leading new research facility

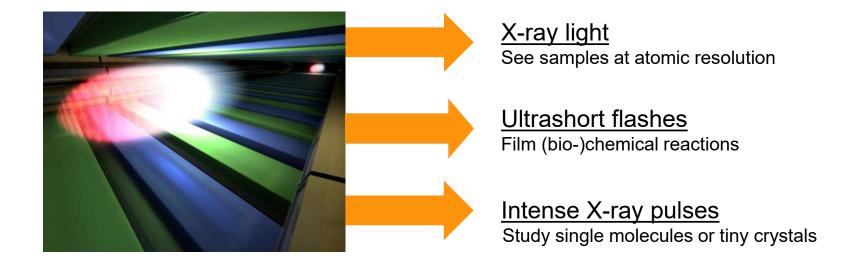


The European XFEL is a new research facility that uses high-intensity X-ray light to study the structure of matter.

- User facility with more than 500 employees (+250 from DESY)
- Location: Hamburg and Schenefeld, Germany

Schenefeld research campus on 14 August 2017

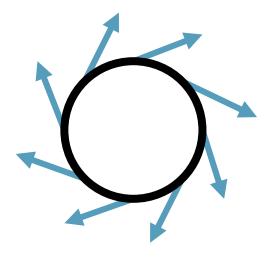
## What can the European XFEL do?



## **Using X-rays to explore matter**

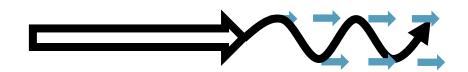
### **Synchrotrons**

- Electrons traveling in a wide circular path,
   emitting light as they change directions
- Light is UV or X-ray, but not coherent



#### **Free-Electron Lasers**

- Electrons accelerated in a straight line and manipulated to generate light
- Light is coherent and intensely bright in very short pulses, showing objects in even more detail and revealing processes



## **About European XFEL**



- Organized as a non-profit corporation in 2009 with the mission of design, construction, operation, and development of the free-electron laser
- Supported by 12 partner countries
- Total budget for construction (including commissioning)
  - 1.25 billion € at 2005 prices, about 140 M€ operating budget
  - 600 M€ contributed in cash, over 550 M€ as in-kind contributions (mainly manufacture of parts for the facility)

**European XFEL—Entwicklung einer Einrichtung** 

We need a strategy for the next phase

Prof. Dr. Massimo Altarelli

2009-2017 Construction



- Increased efficiency
- Increased capacity
- Increased quality
- Investment in science
- Science- and challenge-driven experiments

2024—2030 Prof. Dr. Thomas Harvesting Feurer

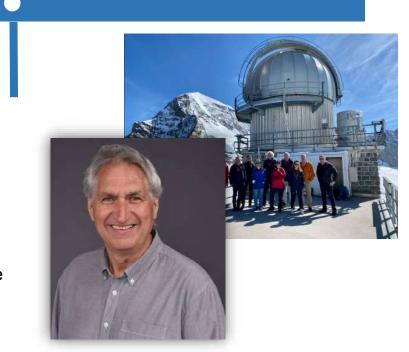
2018-2023 Startup Start of operation

- First science programme
- Many proof-of-concept experiments
- 2022 First year of full user operation (<8 000 instrument hrs)
- New developments needed to keep competitive

Prof. Dr. Robert

Feidenhans'I







2017 - 2020

Three years of operation including the pandemic situation

1261

**USERS** from across the world have visited European XFEL for their experiments since operation began in September 2017.

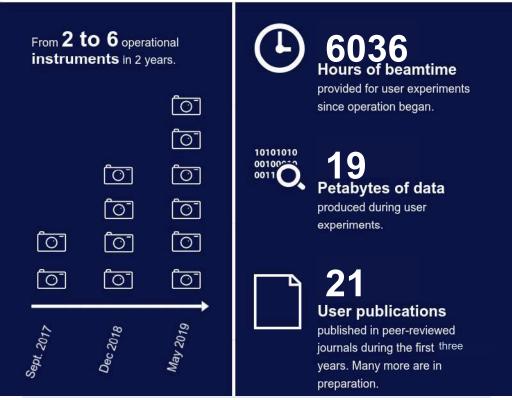
95

**experiments** have been carried out at the facility.

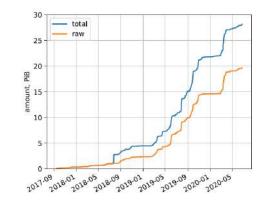


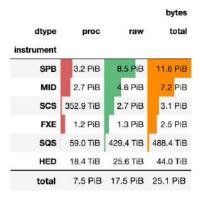
109 Proposals finished or scheduled (i.e. accepted)

**466** Proposals finished or scheduled (i.e. accepted)



#### Data profile





European XFEL



2017 - 2022

Three years of operation including the pandemic situation

2448

**USERS** from across the world have visited European XFEL for their experiments since operation began in September 2017.

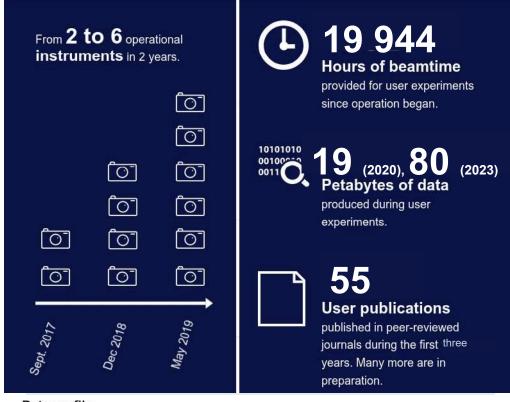
247

**experiments** have been carried out at the facility.

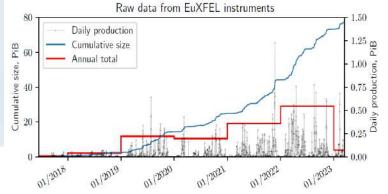


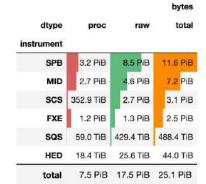
**247** Proposals finished

901 Submitted experimental proposals

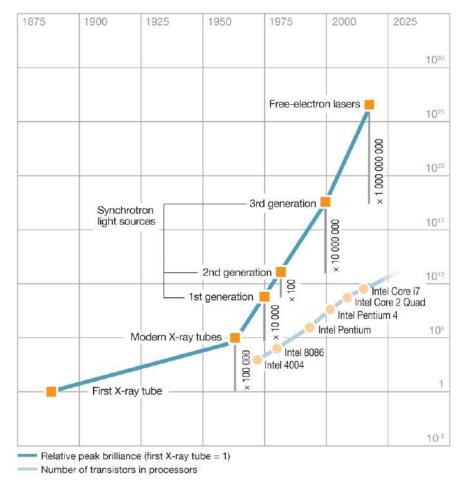


#### Data profile





## **Light source development**

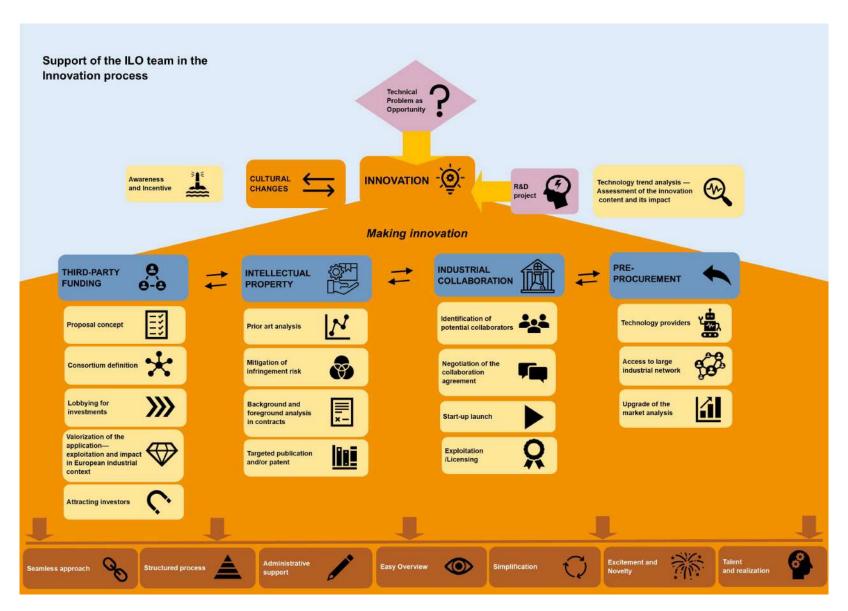


The development of light source facilities has been faster than the increase in computer processing capacity (i.e., Moore's Law)

X-ray free-electron lasers worldwide

Startiplement Nigel – status and challenges

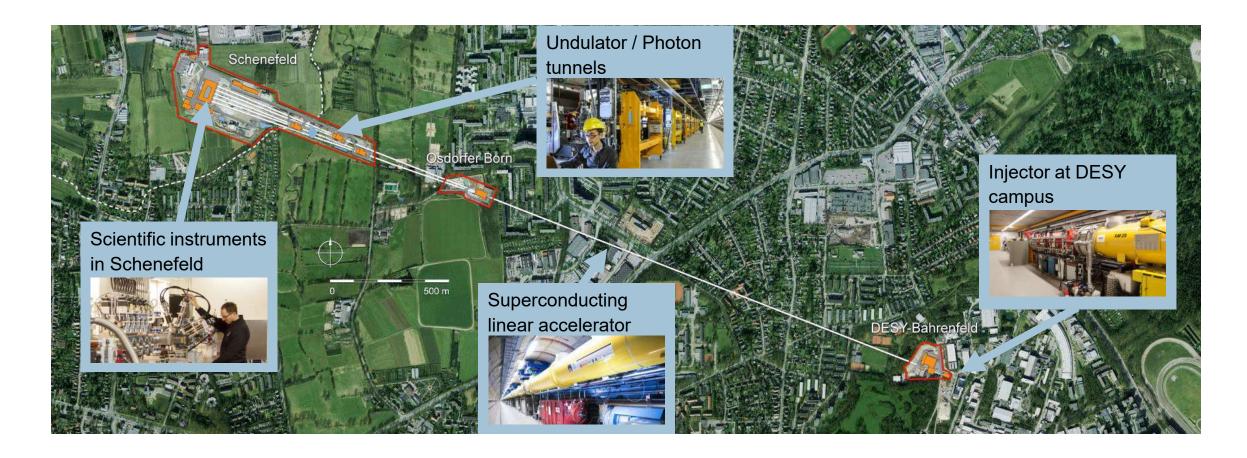
StartipMaaetiXigEL – status and challenges				Antonio Bonucci, In kind contribution manager and Industrial Liaison Office					
Project	FLASH	LCLS CuRF (USA)	LCLS-II SCRF (USA)	SACLA (Japan)	European XFEL	SwissFEL (CH)	PAL-XFEL (S. Korea)	SHINE (China)	FERMI (Italy)
Max. electron energy (GeV)	1.35	15	5.0	8.5	17.5	6.2	10	8	1.55 GeV
Wavelength range (nm)	3.4-90	0.05–5.0	0.25–5.0	0.06–0.3 /8-30	0.05–4.7	0.1–7	0.06–5.0	0.05–3.1	4-100 (1.7-4)
Photons/pulse	~1011-1014	5 x 10 <sup>13</sup>	0.5 - 5 x10 <sup>12</sup>	~5 x 10 <sup>11</sup>	~10 <sup>12</sup> (typical at 12.4 keV)	5 x 10 <sup>11</sup> <sub>(HX)</sub> 1.2 x 10 <sup>14</sup> <sub>(SX)</sub>	1011–1013	1010-1013	3x10 <sup>11</sup> -10 <sup>14</sup> (~10 <sup>7</sup> -10 <sup>8</sup> )
Peak brilliance	1 x 10 <sup>31</sup>	4x1034 (measured at 10 keV)	2 x 10 <sup>33</sup> (simulated at 1.25 keV)	~5 x 10 <sup>33</sup>	3 x 10 <sup>33</sup> (8.3 keV simulated at saturation without seeding)	1 x 10 <sup>32</sup> –1 x 10 <sup>33</sup>	1.3 x 10 <sup>33</sup>	1 x 10 <sup>33</sup>	2x10 <sup>32</sup>
Average brilliance		5 x 10 <sup>22</sup>	3x10 <sup>25</sup>		2 x 10 <sup>24</sup> (8.3 keV simulated at saturation without seeding)				
Pulses/second	8000	120	1 000 000	60	27 000	100	60	1 000 000	50
Experiment Stations (parallel Operation)	7(2)	9	(3)	7 (3)	7 (3)	5 (2)	3 (2) Instruments 7 (2)	10 (3)	6(2)
Date of first beam	2005	2009	2023	2011	2017	2016	2016	2025	2010



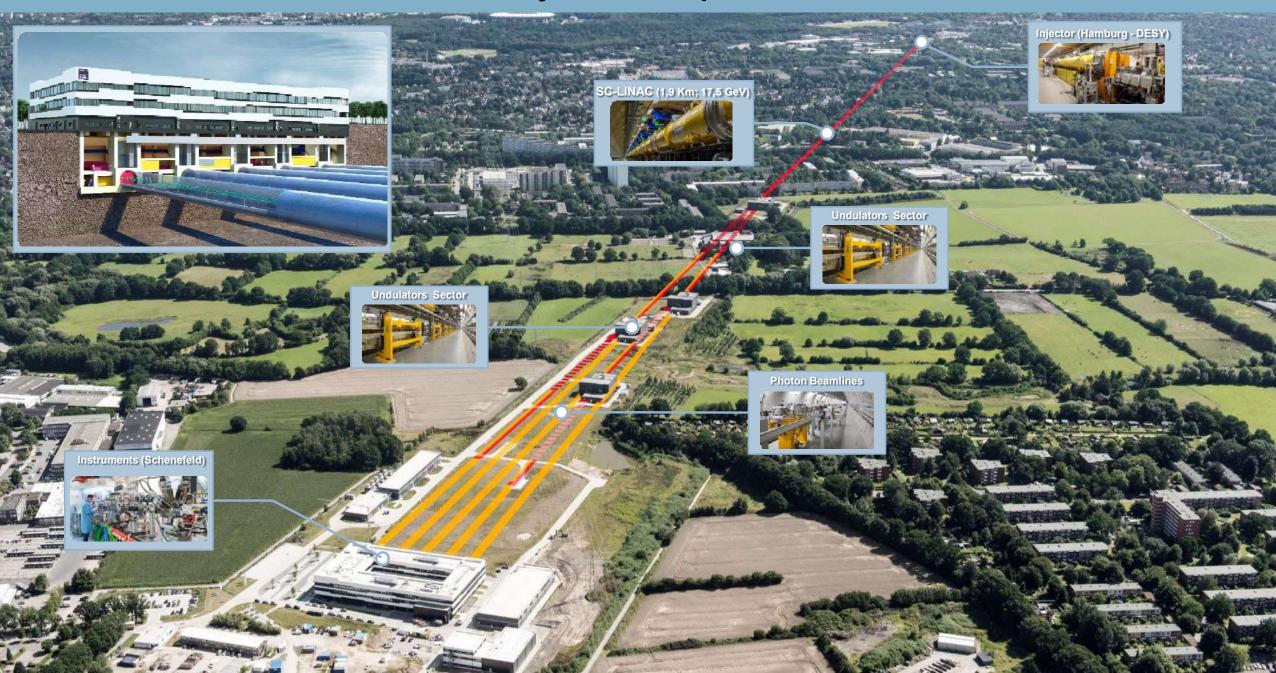
### **Outline**

- General presentation of European XFEL
- Main description of the facility
- Highlights on typical technologies in the experimental hall
- Information about procurement procedures, hints on new internal procedures
- Technologies of interest

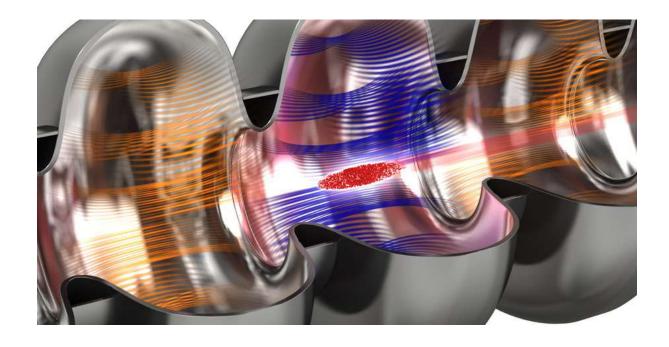
## **General layout of the European XFEL**



## 3.4 km from Injector to Experimental Hall.

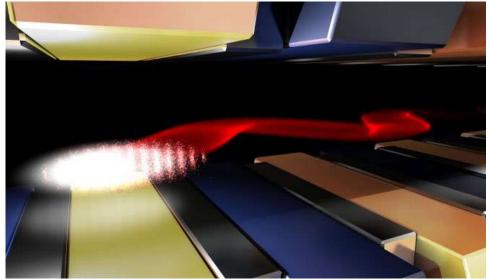


## Accelerator: electrons at close to light speed

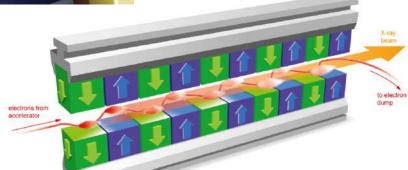


- Superconducting niobium cavities powered by intense radio frequency accelerate electrons
- Ninety-six accelerator modules over 1.7 km bring the electron bunch to near light speed and high energies

# SASE (Self Amplified Spontaneous Emission) undulators: inducing electrons to emit X-ray light



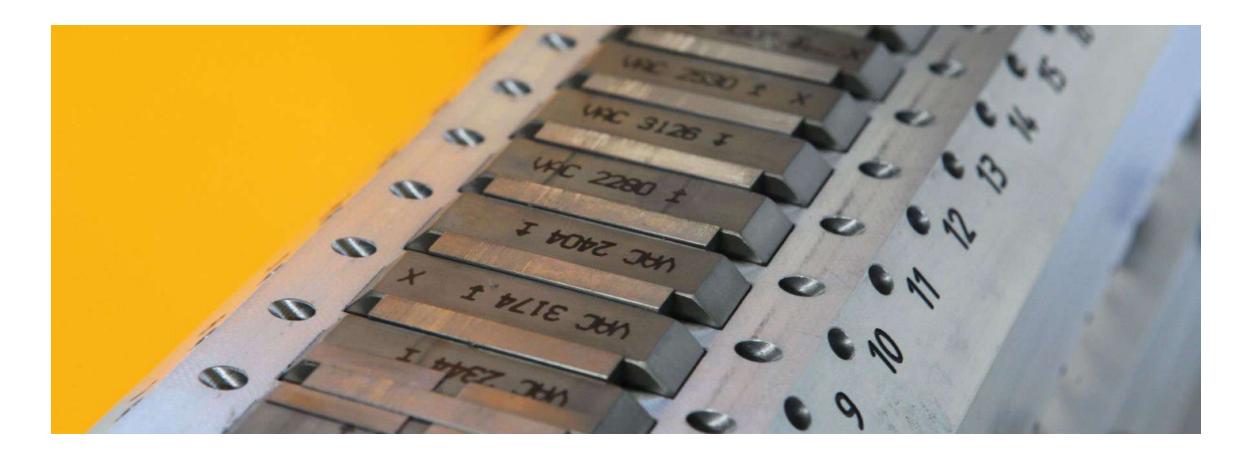
- Alternating magnetic fields cause electrons to take "slalom" course
- Electrons release X-rays with each turn
- SASE process builds intense, laser-like flashes



## **Tuning undulators**



## **Undulator magnets**



## **Undulators in tunnel**



## **Procurement regulation**

#### Please have a look at

https://www.xfel.eu/organization/procurement/legal\_and\_regulatory\_information/index\_eng.html#laws\_and\_regulations

Threshold EU international call for tender

Until the end of 2021, the EU threshold for construction contracts was set at 5.35 M€ and for all other supply and service contracts at 215 k€

Rules of Procedure for the award of public supply and service contracts below the EU thresholds

https://www.xfel.eu/sites/sites\_custom/site\_xfel/content/e35152/e46557/e47200/e47206/xfel\_file47209/UVgO Englisch\_eng.pdf

Procurement Ordinance

https://www.xfel.eu/sites/sites\_custom/site\_xfel/content/e35152/e46557/e47200/e47206/xfel\_file86104/VgV-ordinance-award-of-public-contracts\_eng.pdf

#### Call for tender

- The European XFEL GmbH is a public-equivalent body and is therefore subject to special legal regulations concerning the award of contracts and placement of purchase orders. This includes, for example:
  - **the VOB** ("Verdingungsordnung für Bauleistungen", regulations for civil construction contracts),
  - **the VOF** ("Verdingungsordnung für freiberufliche Leistungen", regulations for freelance and professional services contracts)
  - **the VOL** ("Vergabe- und Vertragsordnung für Leistungen", regulations on contract awards for public supplies and services),

https://www.xfel.eu/organization/procurement/legal\_and\_regulatory\_information/index\_eng.html

The award of contracts and placement of purchase orders fall under the responsibility of the Procurement Group

#### **General Purchase Conditions**

Due to the fact that we are a government-funded organization, we are not allowed to accept other terms and conditions than these. Please read them carefully and include them as part of your public tender documentation.

https://www.xfel.eu/sites/sites\_custom/site\_xfel/content/e35152/e46557/e47200/e47202/xfel\_file47204/EuXFEL\_GeneralTermsConditions\_01Oct2023\_eng.pdf

#### **General Purchase Conditions**

If the delivery or service resulting from a works contract is carried out in accordance with the contractual conditions, it will be accepted. If a test run is agreed, the delivery or service is deemed accepted by means of a joint acceptance report after a flawless test run.

In addition, the Goods to be delivered must comply with the applicable safety regulations (e.g. EU Directive 2006/42 on machinery. EU Directive 2014/35 on the market of electrical equipment designed for use within certain voltage limits, EU Directive 2014/30 relating to electromagnetic compatibility, EU Directive 2014/68 on the market of pressure equipment, EU Directive 2011/65 on the restriction of the use of certain hazardous substances in electrical and electronic equipment. German Product Safety Act (ProdSG - Act on making products available on the Market) and be provided with all prescribed markings (e.g. CE mark), declarations (e.g. declaration of conformity, declaration of incorporation) and documents (e.g. operating instructions, assembly instructions, safety data sheets). Protective devices, markings, declarations, and documents required according to such regulations shall be taken into account in the Contractor's calculation and shall be part of the scope of delivery, even if they are not requested separately by the Client.

## Property rights

### **General Purchase Conditions**

The Contractor shall keep all images, drawings, calculations, and other documents and information (hereinafter referred to as "Confidential Information") received for the execution of the Purchase order strictly confidential and to disclose them only to employees who have been obliged to treat them confidentially. Confidential Information may only be disclosed to third parties with the prior written consent of the Client, which must be granted in the event of proven judicial or statutory claims for disclosure. The obligation to maintain confidentiality shall also apply after the termination of this contract; it shall expire - unless otherwise agreed - five years after the conclusion of the contract or if and to the extent that the Confidential Information has become public domain.

The Contractor is liable for ensuring that no third-party property rights are violated during the execution of the contract and during the delivery and use of the delivered item or service. Upon first written request, the Contractor shall indemnify the Client against any third-party claims arising from any property right infringements.

The Client is entitled to obtain the necessary authorization for delivery, commissioning, use, resale, etc. of the delivery item or service from the owner of such property rights at the Contractor's expense if the Contractor is unable to obtain such rights, finally refuses such subsequent performance, or is in default with subsequent performance.

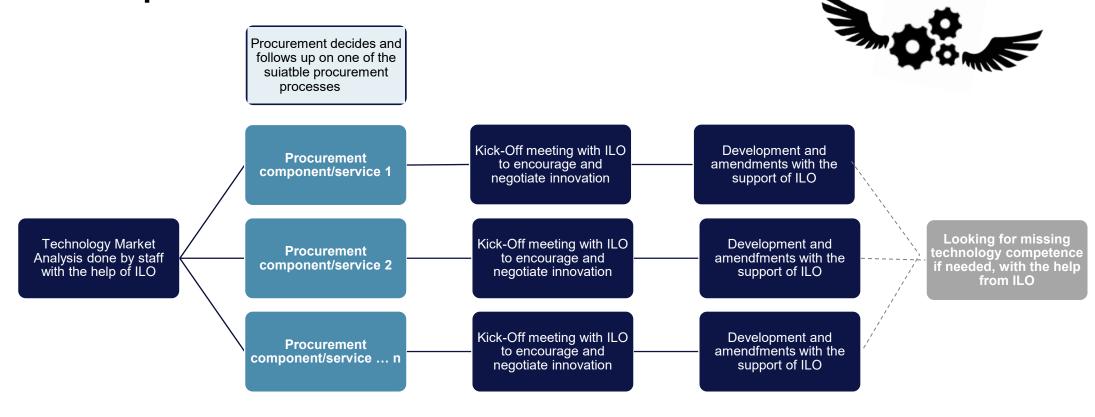
The Contractor shall grant the Client free-of-charge a non-exclusive and irrevocable license to all domestic and foreign property rights, applications for property rights, and inventions, insofar as they have arisen during the performance of this contract. Furthermore, the Contractor shall grant the Client free-of-charge an irrevocable and non-exclusive right to use all know-how and every innovation and improvement, insofar as these have arisen during the performance of this contract. The Client is entitled to transfer licenses and rights of use within the meaning of the above paragraph to its shareholders. This shall also apply beyond the term of this contract. The Contractor shall expressly agree the above rights with its subcontractors for the benefit of the Client.

#### **General Purchase Conditions**

The Contractor shall, no later than two weeks after placing the Purchase order, notify the Client independently and in writing for each individual item of all information and subsequent changes thereto required by the Client for compliance with foreign trade and payments law in the case of export, import, and re-export, in particular:

- 3.2. All applicable export list numbers, in particular in accordance with Annex AL to the German Foreign Trade and Payments Regulation (AWV) or comparable list positions of relevant export lists including the "Export Control Classification Number" in accordance with the "US Commerce Control List" (ECCN), if the Goods are subject to the "US Export Administration Regulations" (EAR);
- 3.5. All information of the Contractor required by the Client for the fulfillment of its obligations under the EU Regulation 2023/956 establishing a carbon border adjustment mechanism; and

## Innovation procurement workflow





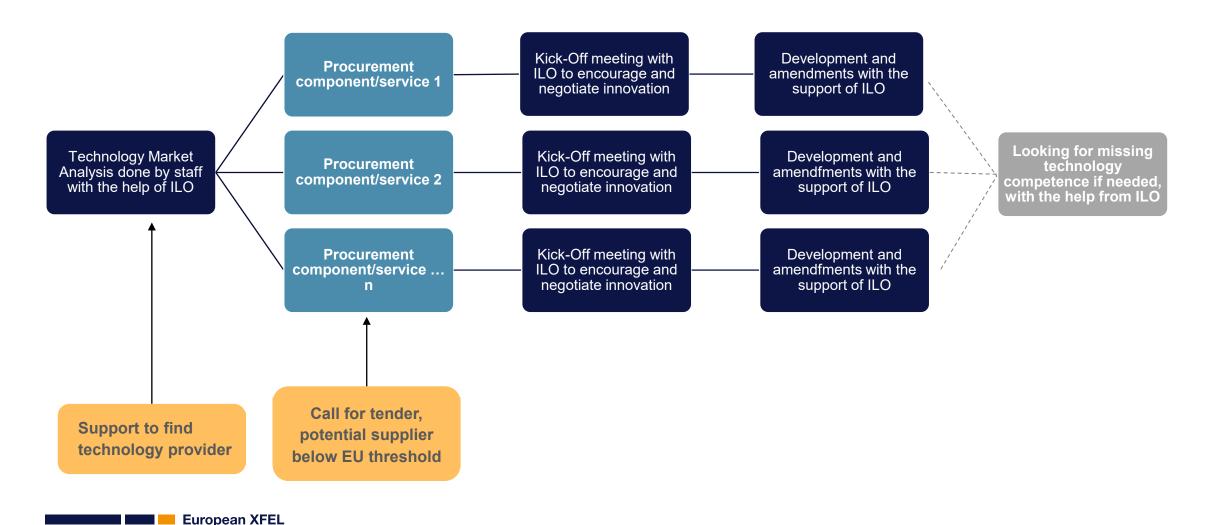








## Innovation procurement workflow: National ILO involvement







# Supplier Database: https://in.xfel.eu/thesurvey/index.php/782712?lang=en

	Resume later	Exit and clear survey
XFEL EUROPEAN XFEL - SURVEYS		
0%		

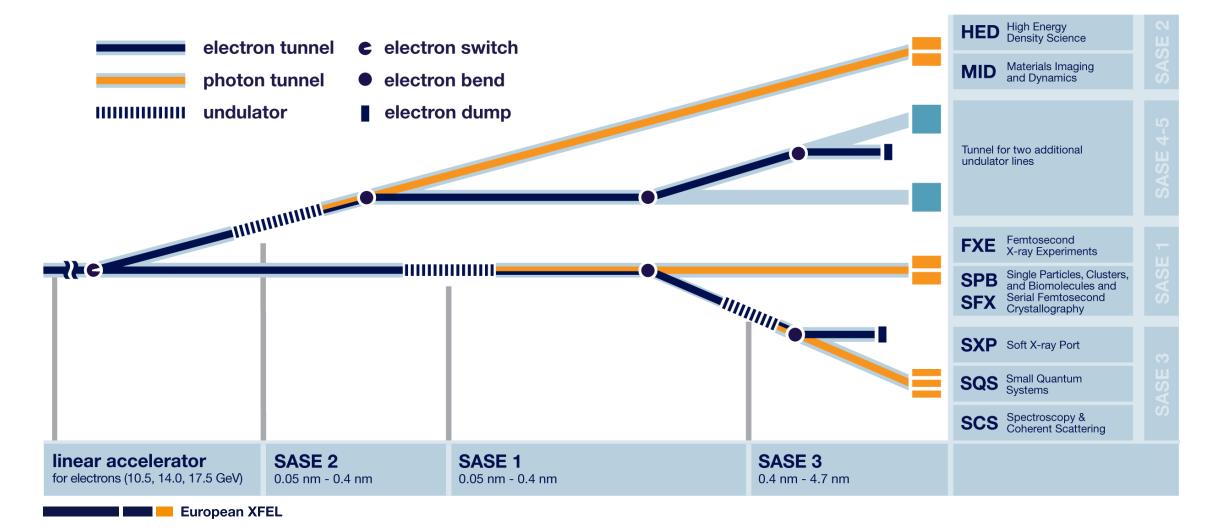


General information				
*Company name				
*Contact name				
*E-mail				
*Job title				
*Telephone				
♦What is your core husiness model?				

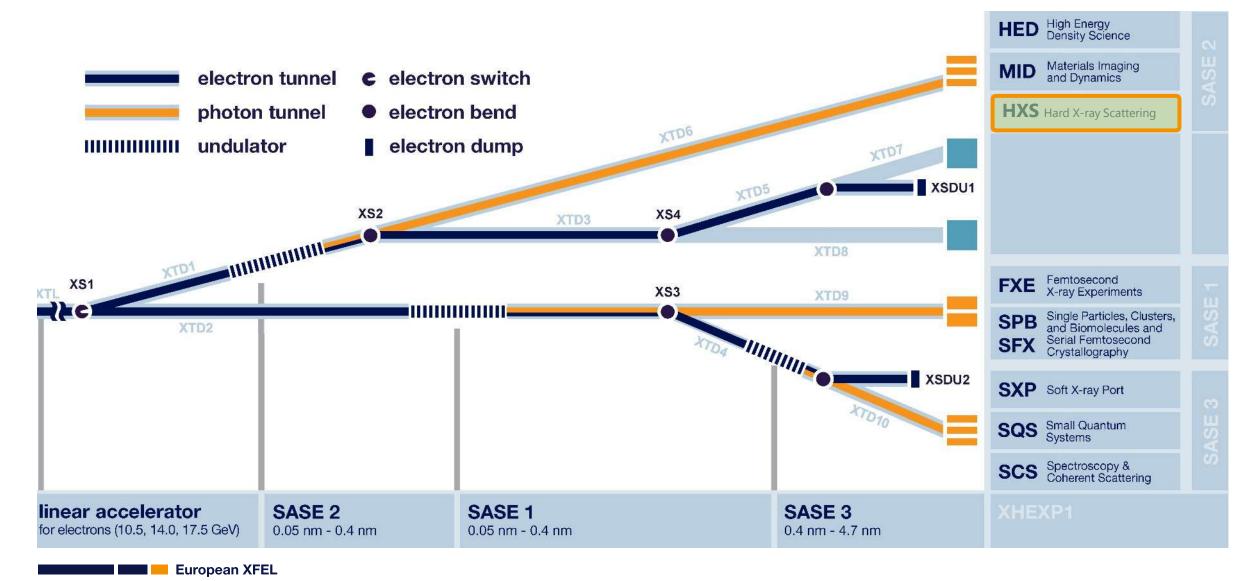
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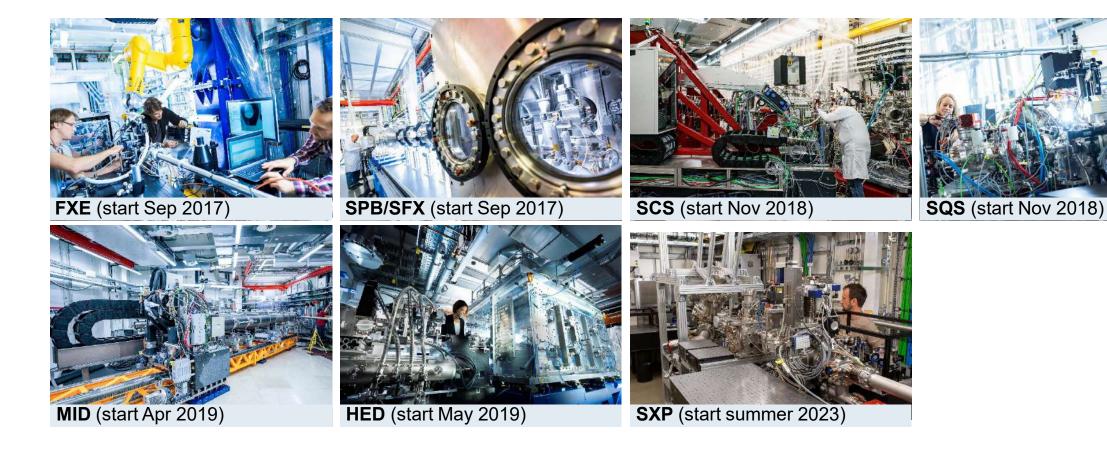
## Beamline layout and experiment stations



## This decade: SASE2 Beamline 3<sup>rd</sup> port



## **Seven scientific instruments**



## **Photon Beam Transport System**

- According to XFEL UHV Guidelines.
- Outsourced manufacturing and cleaning.
- "Particle free" specifications (ISO Class 5/6).
- Sectorization & Mobile clean tents.
- In-situ conditioning (specific cases): wet-cleaning, baking, plasma cleaning...
- Hundreds of meters beampipe (flanged and in-situ orbital-welded sectors)
- Standard vacuum components:
  - Pumping Stations
  - Beamline Pumping equipment (mechanical, SIP's, NEG's)
  - Controller for pumps, gauges...
  - Gauges, RGA's,...
- PLC Control system (racks, terminals, interfaces).
  - PLC terminals
  - Power supplies, connectors, cables
  - Controller for pumps, gauges...









## Some "sizing" numbers for vacuum...

- Construction phase (2011-2017)
  - Accelerator warm vacuum system: 6 M€
  - Accelerator cold vacuum system : 5 M€
  - Photon beamlines (warm) vacuum system: 8 M€
- Operation-related averaged procurement(\*)
  - Accelerator cold vacuum system: 250 k€/year
  - Accelerator warm vacuum system: 500 k€/year
  - Photon beamlines (warm) vacuum system: 600 k€/year

#### Die Vakuumsysteme des European XFEL Ultrahochvakuum ermöglicht Betrieb des neuen Röntgenlasers der Superlative und erlaubt bisher unerreichte Einblicke in den Nanokosmos. Martin Dommach, Sven Lederer, Lutz Lilje kete weiter verdichtet. Der Transport Der European XFEL ist eine interna dieser sehr intensiven, komprimierten tionale Forschungseinrichtung der Elektronen- und Photonenstrahlpakete Superlative: 27 000 Lichtblitze pro Se-stellt viele besondere Anforderungen kunde mit einer Leuchtstärke, die mil- an die umgebenden Vakuumsysteme liardenfach höher ist als die der besten [1,2] (Abb. 1 und 2). Röntgenguellen herkömmlicher Art. Im European XFEL gibt es mehrere eröffnen vielfältige neue Forschungs- große Vakuumsysteme mit höchst unmöglichkeiten. Wissenschaftlerteams terschiedlichen Anforderungen: aus der ganzen Welt untersuchen am Die Vakuumsysteme in denen der Elektronen- bzw. Photonenstrahl European XFFI Strukturen im Nanobereich, ultraschnelle Prozesse und transportiert wird: extreme Materiezustände, nehmen > Das isollervakuumsystem für die su-ARRII DUNG 1-Fines der ersten Döntne praleitenden Beschleunigermodule beugungshilder des European XFEL, aufgene und der Heliumversorgung: Proteinen auf und filmen chemischen men durch eine etwa einen Millimeter groß Reaktionen. Die neue Forschungsein Das zusätzliche Vakuumsystem der quadratische Blende am Instrument SPB/SFX richtung wird von der European XFEL Hochfrequenzeinkoppler der supra- Das gleichmäßige, netzartige Muster zeigt die GmbH betrieben, einer gemeinnütleitenden Beschleunigermodule. hohe laserartige Qualität des Lichtstrahis. zigen Gesellschaft, die eng mit ihrem In diesem Beitrag wird vorrangig auf die Hauptgesellschafter, dem Forschungs Vakuumsysteme des Elektronen bzw. zentrum DESY, und weiteren wissen- Photonenstrahltransports eingegan schaftlichen Einrichtungen weltweit gen. Das Elektronenstrahlvakuum ist in unterteilt in mehrere Sektoren: Iniek Für die Erzeugung des Röntgenlich- mehrere Abschnitte aufgeteilt, wobei tion, Elektronenpulskompression, Kollites werden hochenergetische Elektro- eine wesentliche Unterscheidung zwi- mation, Undulatorbereich sowie Strahinenpakete durch eine periodische Mag- schen dem Teil der supraleitenden Be- transport. Alle diese Sektoren sind mit netfeldanordnung im sogenannten schleunigungsmodule mit der Betriebs- detaillierten Spezifikationen aus den Undulator transportiert. Dahei beginnt - temperatur von 2 K und dem restlichen - Bereichen Vakuum, elektrischer Leitfä-Beschleunigervakuum bei Raumtempe- higkeit und Magnetisierbarkeit. Oberder Lichtfeldes mit dem Elektronenpa- ratur gemacht wird. Der Raumtempe- flächengüte, Reinheitsklasse in Bezug ket ein sich selbstverstärkender Prozess, raturteil wird aufgrund der Vielzahl ver- auf Partikelfreiheit sowie Fertigungs der schließlich einen Röntgenlaserpuls schiedener Anforderungen wiederum und Aufstelltoleranzen versehen. erzeugt. Dieser auch SASE (Self Amplified Stimulated Emission) genannte Vorgang wird auch bei verschiedenen ZUSAMMENFASSUNG anderen Lichtquellen eingesetzt. Der besonders hohe Strahlstrom, der mit Für den European XFEL ist Vakuum sind viele Komponenten speziell für dem supraleitenden System des Euroeine Grundvoraussetzung für den den European XFEL entwickelt worpean XFEL beschleunigt werden kann. erfolgreichen Betrieb. Neben den Va- den, um z.B. die hohe Elektronenermöglicht die sehr hohe Leuchtstärke. kuumeigenschaften war dafür eine strahlgualität zu gewährleisten. Durch Damit der SASE Prozess funktionieren Vietzahl anderer Randbedingungen redundante Auslegung und Segmenkann bedarf es sehr hoher Spitzenan die Komponenten zu erfüllen. Her- tierung des Vakuumsystems konnte stromstärke und sehr guter Brillianz vorzuheben ist hier insbesondere die die Inbetriebnahme in kürzester Zeit der Elektronenpakete. Diese werden im erforderliche Reinheitsklasse, die für erfolgreich stattfinden. Die ersten Ex-Injektorteil des Beschleunigers mittels ein kilometerlanges System des Teil- perimente mit dem Röntgenlaserlicht einer Hochfrequenzelektronenguelle chenbeschleunigers und bei den Rönt- haben bereits stattgefunden. erzeugt. In drei Elektronenpulskomgenoptiken erreicht wurde. Außerden pressoren werden die Elektronenpa Vol. 30 Nr. 2 April 2018 VIP 47 #2018 WILEY VCH Verlag GerbH & Co. KGoA, Weinheir DOI:10.1002/vipr.201800673

https://onlinelibrary.wiley.com/doi/full/10.1002/vipr.201800673

## Hybrid permanent magnet undulators at European XFEL

Table 1
Specifications for the undulator segments of the EuXFEL.

The operational ranges for gap and K parameter match user requirements (Altarelli et al., 2006). Only inside are all specifications strictly fulfilled. Magnetic tuning was always performed at the tuning gap to limit gap dependence of magnetic properties, see discussion of Fig. 4.

	SASE1 / SASE2	SASE3
Undulator type	U40	U68
Period length (mm)	40	68
Segment length (m)	5	5
Total number of poles	248	146
Magnetically active poles	246	144
Number of ending poles	3	3
Operational gap range (mm)	10-20	10-25
Operational K-parameter range	1.65-3.9	4-9
Maximum peak field @ 10 mm (T)	1.11	1.66
Tuning gap (mm)	14	16
Maximum gap (mm)	200	200
Maximum phase jitter (°)	≤8	≤8
Maximum 1st $B_v$ field integral (T mm)	$\pm 0.15$	$\pm 0.15$
Maximum 1st $B_x$ field integral (T mm)	$\pm 0.15$	$\pm 0.15$
RMS of 2nd $B_v$ integral (T mm <sup>2</sup> )	<100	<210
RMS of 2nd $B_x$ integral (T mm <sup>2</sup> )	<100	< 100
Radiation wavelength range (nm)	0.05-0.4	0.4 - 5.2
Number of segments in system	35	21
System length (m)	205	121



## Typical undulator cell at European XFEL

**Undulator Cell** Servo Motor AlMg Girder e- beam

**European XFEL planar undulators** for SASE1/2/3 are hybrid permanent magnet undulators using NdFeB and soft iron poles made of cobalt iron

The beam vacuum chamber is made of extruded aluminum-magnesium and has an elliptical beam stay clear of 15 mm (horizontal) and 8.6 mm (vertical)

50 mm x 100 mm Servo Motor **Undulator 5 m** Intersection 1.1 m

## Components for SCU development at EuXFEL

- Part of the SCU module:
  - Cryocoolers
  - Power supplies
    - ► Correctors and phase shifter: ±10 A, 10 V
    - ► Main coils: 400-1000 A, 10-20 V as small as possible to fit in the tunnel
  - Vacuum pumps
  - CAM movers
- Elements for intersections:
  - Quadrupoles, Quadrupole movers, Air coils
  - Granite stone, alignment mechanism
  - Absorbers, BPMs, BLMs
  - Phase shifters
  - RF bellows, RF valve

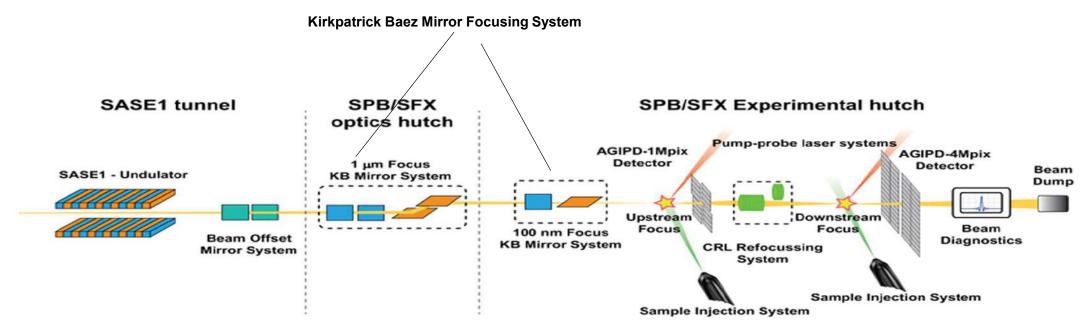
- SUNDAE1/2
  - CuBe wires
  - Vacuum pumps
  - Hall probes + readout and current source
  - Temperature sensors and monitors
  - In vacuum (UHV) motors and linear stages
  - ...
- Advanced SCU coils
  - NbTi wires, HTS tapes
  - Precisely machined iron few tenths  $\mu$ m
  - Epoxy, kapton
  - ...

European XFEL

## **SPB/SFX Instrument**

https://www.xfel.eu/facility/instruments/spb\_sfx/science\_programme/index

- Diffractive imaging of micrometre-scale and smaller objects, at atomic or near-atomic resolution.
- Structural dynamics on the millisecond to femtosecond timescale.
- It consists of two experiment endstations (upstream and downstream),



## **SPB/SFX Instrument**

European XFEL

## https://www.xfel.eu/facility/instruments/spb\_sfx/science\_programme/index

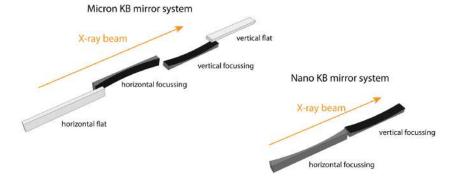
MHE	Micron horizontal elliptical KB
Deflection	Horizontal (negative x)
Source—optic (centre) distance	894.779 m
Optic (centre) focus distance	24.005 m
Saggital radius (minimum)	10 km

Controlled motion (relative to incident beam)	Minimum	Maximum	Resolution
X	-2 mm	+10 mm	<1 μm
Y (coating selection)	-15  mm	+15  mm	$<1 \mu m$
$\theta_y$ (pitch)	-0.5  mrad	+5.5 mrad	<20 nrad

#### Kirkpatrick Baez Mirror Focusing System

17							
NHE	Nanometer horizontal elliptical KB						
Deflection	Horizontal (positive x)						
Source-optic (centre) distance	915.484 m						
Optic (centre) focus distance	3.3 m						
Saggital radius (minimum)	10 km						

Controlled motion (relative to incident beam)	Minimum	Maximum	Resolution	
X	-10 mm	+5 mm	$<1 \mu m$	
Y (coating selection)	-15 mm	+15 mm	$<1 \mu m$	
Z (astigmatism correction)	-5 mm	+5 mm	$<1 \mu m$	
$\theta_{v}$ (pitch)	-0.5 mrad	+5.5 mrad	<20 nrad	

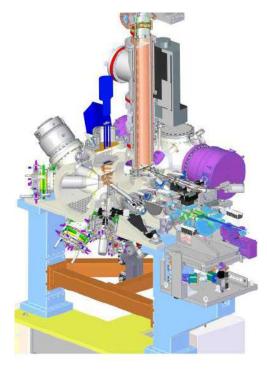


J. Opt. 18 (2016) 074011 https://iopscience.iop.org/article/10.1088/2040-8978/18/7/074011

## **SQS Instrument**

## https://www.xfel.eu/facility/instruments/sqs/index\_eng.html

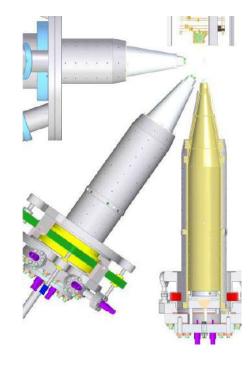
Investigations of fundamental processes of light-matter interaction in the soft X-ray wavelength regime.



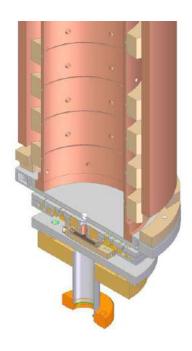
Atomic-like Quantum Systems (AQS) quantum systems, i.e. free atoms or small molecules.

The alignment of the AQS chamber with respect to the FEL beam is realized with a set-up enabling translation (50 mm) and rotational movements of the

vacuum chamber with a precision of less than 0.5 µm.



Electron Time-Of-Flight (eTOF) In combination of fast digitizer, (till 4.5 MHz) Detector MCP, 450 ps timing resolution

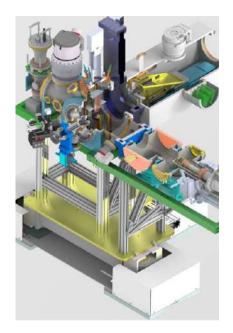


Magnetic Bottle Electron Spectrometer (MBES)
Time of flight spectroscopy

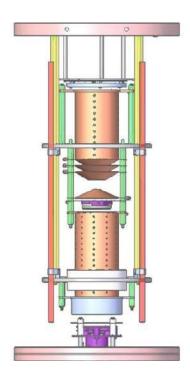
## **SQS Instrument**

#### https://www.xfel.eu/facility/instruments/sqs/index\_eng.html

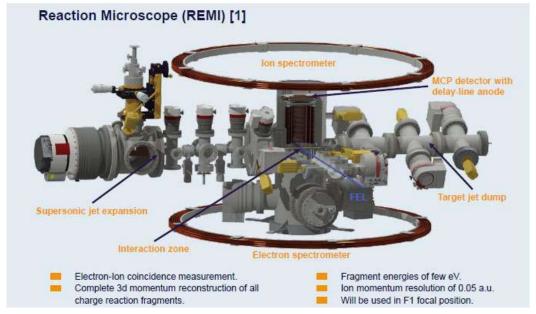
Investigations of fundamental processes of light-matter interaction in the soft X-ray wavelength regime.



Nano-sized Quantum Systems (NQS) Nanoparticle The vacuum conditions in the NQS chamber are mainly limited by the imaging detector and are at best about 10<sup>-10</sup> mbar



Ion Time-Of-Flight (iTOF- Wiley-McLaren design) Velocity Map Imaging (VMI) spectrometer



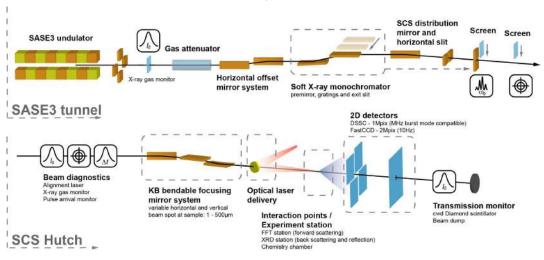
A Reaction Microscope (REMI) ion and electron momentum imaging experiments in the gas phase: a three-stage supersonic gas jet four piezo-controlled apertures, nozzle 5 µm to 300 µm, temperatures from 5 K to 450 K

#### Antonio Bonucci, In kind contribution manager and Industrial Liaison Office

## **SCS Instrument**

https://www.xfel.eu/facility/instruments/scs/index\_eng.html

- Enables time-resolved experiments to unravel the electronic and structural properties of complex materials, molecules, and nanostructures in their fundamental space-time dimensions.
- The SCS instrumentation is equipped with:
  - the FFT experiment station (forward-scattering and transmission geometries)
  - the XRD experiment station (back- scattering and reflection geometries).
  - 2D array detectors, the 1MPix DSSC detector (4.5 MHz rep rate) and the 2Mpix FastCCD detector (10Hz), for coherent x-ray diffraction experiments
  - A high-resolution Resonant Inelastic X-ray Scattering (RIXS) spectrometer
  - a chemistry chamber station for liquid jets will be available in addition to the XRD experiment station.



Parameter	Current Value
Photon energy	0.5 keV – 3.0 keV
X-ray pulse duration	10-25 fs fwhm
X-ray pulse stretching	80-150 fs (mono HR)
(Expected durations based on	30-50 fs (mono LR)
Monochromator)	
X-ray polarization	Linear horizontal (π-polarization)
	Linear vertical and circular polarizations may
	become available during 2022
X-ray focal spot size at sample	5 μm (hor & ver)
	tunable up to 500 μm
Mono resolving power	10.000 (HR)
	3.000 (LR)
Photon energy hRIXS	0.5 keV – 1.4 keV
Combined resolving power	Up to 10.000
(Monochromator & hRIXS)	

## **SCS Instrument**

https://www.xfel.eu/facility/instruments/scs/index\_eng.html

## X-ray diffractormeter Inner Mechanics

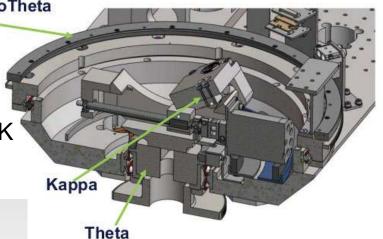
Triple-rotating flange to TwoTheta change scattering angle

Sample: 6 DOF

UHV (p< 10-9mbar)</p>

Temperatures: RT – 20 K

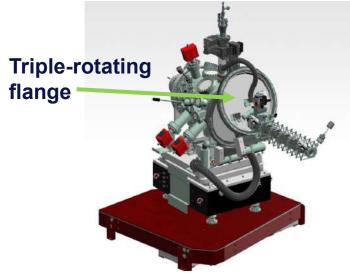
Sample transfer system



**Cu-braids** 

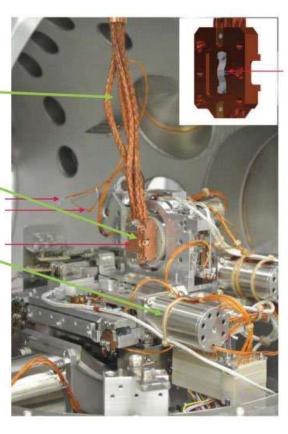
Sample holder

Motors for translations



**European XFEL** 

Motion	Range	Repeatibility
TwoTheta	± 180 deg	< 1 µrad
Theta	± 180 deg	< 1 µrad
Карра	± 30 deg	< 1 µrad
Azimuth	± 90 deg	< 0.0002 deg
Х	± 5 mm	0.5 µm
Υ	± 5 mm	0.5 µm
Z	± 5 mm	0.5 µm



## **MID Instrument**

#### https://www.xfel.eu/facility/instruments/mid/index\_eng.html

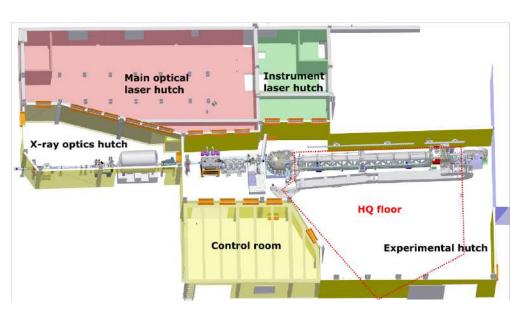
The scope of the MID instrument are material science experiments. The scientific applications reach from condensed matter physics, studying for example glass formation and magnetism, to soft and biological material, such as colloids, cells and viruses.

#### Special Optics:

- 2 monochromators (Si111 and Si220)
- 2 compound refractive lens (CRL) transfocator units
- Split and delay line
- High-energy Laue monochromator (optional)
- Mirror in experiment hutch (for grazing incidence liquid scattering)

#### Equipment:

- Multipurpose chamber
- SAXS/WAXS geometries with long horizontal detector arm
- Small vertical WAXS setup
- Single-pulse X-ray diagnostics
- Different detector systems (AGIPD, FastCCD)
- Optical pump laser source



# MID Instrument

## https://www.xfel.eu/facility/instruments/mid/index\_eng.html

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#### Special Optics:

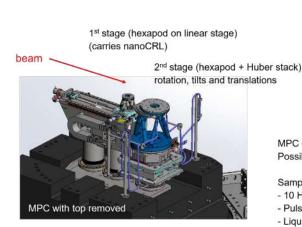
- 2 monochromators (Si111 and Si220)
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- Mirror in experiment hutch (for grazing incidence liquid scattering)

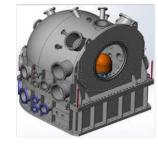
#### Equipment:

- Multipurpose chamber
- SAXS/WAXS geometries with long horizontal detector arm
- Small vertical WAXS setup
- Single-pulse X-ray diagnostics
- Different detector systems (AGIPD, FastCCD)
- Optical pump laser source

Several different detector configurations can be achieved at the MID instrument. The option to operate a very long (8 m) horizontal scattering arm is a special feature of the instrument. The horizontal arm can move continuously in an angular range from 0° to 50°.

A floor with a flatness (1mm in 10 m) has been installed

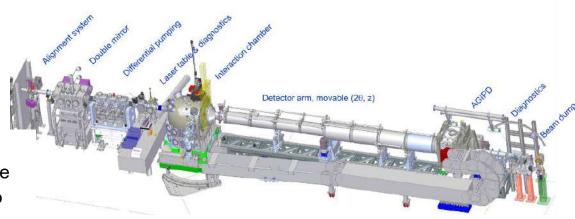




MPC operates under vacuum, windowless config. Possibility to work without lid (in air or He bag)

#### Sample environment

- 10 Hz solid sample scanner
- Pulsed B field (Up to ~15T, 1 ms pulse)
- Liquid iet



## **MID Instrument**

https://www.xfel.eu/facility/instruments/mid/index\_eng.html

## Split and delay line (SDL)

Separate positioning stages mounted to the optical bench for all optical elements

#### Demands:

Providing a fast long-range travel – in some cases of up to 1000 mm

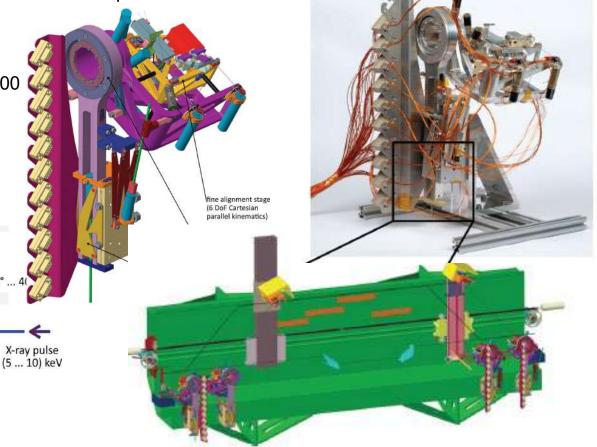
Allowing a precise alignment with a resolution in the range of single nanometre and tens of nanoradians

Conceptual view of the SDL indicating the mechanical concept.
a) beam splitters; b) upper branch crystals; c) channel cuts; d) beam merger.

## Positioning stage for the beam splitter.

 Serial combination of coarse motion axes with a fine alignment stage

The fine alignment stage is implemented as a 6 DoF Cartesian parallel kinematics.



800) ps

## **HED Instrument**

https://www.xfel.eu/facility/instruments/hed/index\_eng.html

Combining hard X-ray FEL radiation and the capability to apply extreme conditions of pressure, temperature or electric field using the FEL, high energy optical lasers, or pulsed magnets.

https://www.xfel.eu/virtualtour/#node42

- Diamond Anvil Cells (available)
   dynamic DAC; pulsed laser heated DAC; double-stage
   DAC
- Powerful optical lasers (2020-2021)
   100 J 15 ns 10 Hz; 400 TW 30 fs 10 Hz
- XFEL split&delay line (2021) x-ray pump-probe, 0-20 ps delay
- 60 T pulsed magnetic field coil (2021)
   cryogenic sample environment, superconductivity

The goal will be to achieve pressures of 1 TPa and temperatures up to 10 000 K using 5 ns, frequency-doubled 50 J pulses from the DiPOLE100X laser focused to 100  $\mu$ m

#### Additional laser

	Abbreviation	Repetition [Hz]	Wavelength [nm]	Pulse energy	Pulse duration	Max. power or B field	Remarks
Pump- probe laser	PP-OL	4.5 M	~ 800	0.2 mJ / 4.5 MHz 5 mJ / 200 kHz	15–00 fs	10–250 GW	NOPA
		200 k	~ 1030	100 mJ	0.8 ps or 0.5 ns	~ 100 GW	Yb amplifier
High- energy	HE-OL	1–10	1057 or 1064	∼ 150 J/ଉ ∼ 100 J/2ଉ	2–20 ns	~ 75 GW	Nd-glass or Nd-YAG
laser		< 1	528 or 532	> kJ	2–20 ns	> 500 GW	Beyond 2016
Ultrahigh- intensity	UHI-OL	10	~ 800	3–5 J	~ 30 fs	~ 100 TW	Ti- sapphire
laser		~ 1		10–30 J	~ 30 fs	~ PW	Beyond 2016
High-field pulsed	HFM	0.1 – ~ 0.01	_	~ 30 kJ	> 100 µs	> 30 T	_
magnet		< 0.01	_	> MJ	_	TBD	Beyond 2016

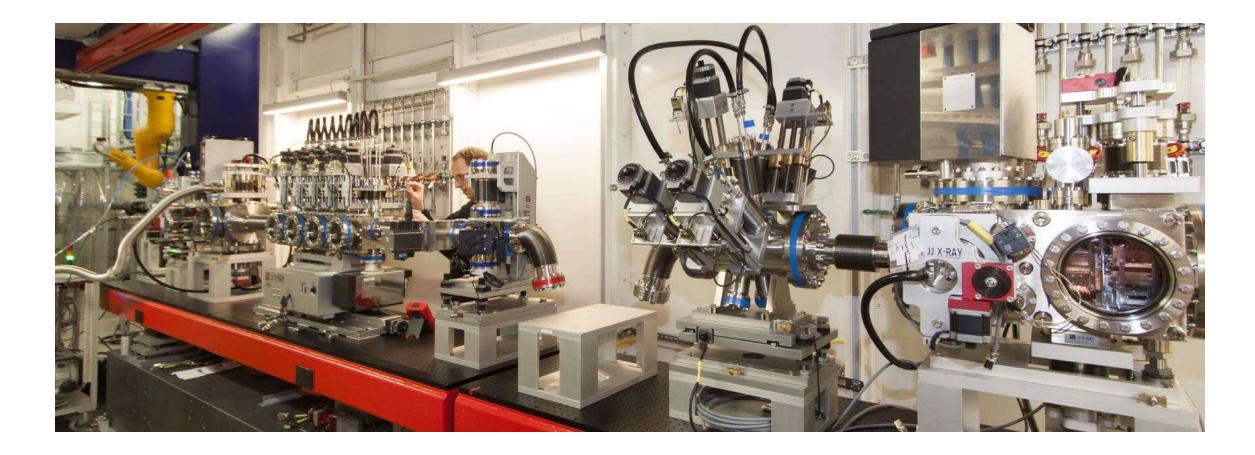
## **FXE Instrument**

https://www.xfel.eu/facility/instruments/fxe/index\_eng.html

- Enables ultrafast pump-probe experiments on ultrafast timescales—below 100 femtoseconds
- Supported techniques:
  - X-ray diffraction (XRD)
  - X-ray diffuse scattering (XDS), or wide-angle X-ray scattering (WAXS)
  - X-ray emission spectroscopies (XES): non-resonant, or resonant inelastic Xray scattering (RIXS)
  - X-ray absorption spectroscopies: X-ray absorption near-edge structure (XANES), or extended X-ray absorption fine structure (EXAFS)

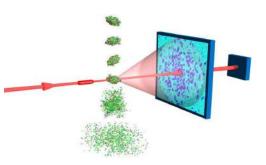
Parameter	Current value						
Photon energy range	5–20 keV						
Polarization	Linear (horizontal), circular (future option)						
X-ray pulse duration	50 fs FWHM						
Beam size	8–200 μm adjustable (via several Be lenses)						
Special optics	1 primary 4-bounce Si(111) mono						
Special optics	2 secondary (von Hamos, Johann) spectrometers						
	Pump-probe (0.1-1 mJ) 800 nm (15-100 fs)						
Optical laser	Pump–probe (200 μJ) 800 nm (50 fs, 15fs possible), harmonics, TOPAS						
wavelengths	adjustable UV-vis-NIR Pump–probe (>20 mJ) 1030 nm (850 fs)						
	Pump–probe (>50 μJ) 1 mm (=0.3 THz) generated via optical rectification						
	APD (0D, full rep. rate with MHz DAQ)						
	Gotthard (1D, 1280 px, 50 µm pixel pitch, 0.9 MHz)						
X-ray detectors	Jungfrau (2D, 1024 x 1024 px, 75 x 75 μm pixel size, 10Hz)						
	LPD (2D, 1 Mpx, (500 µm) <sup>2</sup> pixel size, 512 frames at 4.5 MHz, 3-fold						
	dynamic gain covering 1 (SP at 12keV) to 1x10 <sup>4</sup> per pixel)						

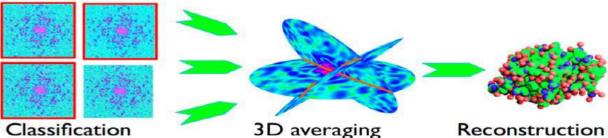
# **Assembling the scientific instruments**

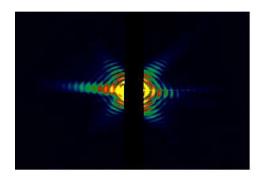


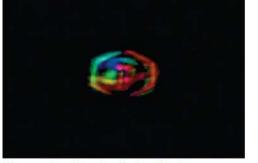
# In-kind contribution SE01 for WP79 Sample Injection Technology











Reconstruction by Anton Barty Relaxed Averaged Alternating Reflection

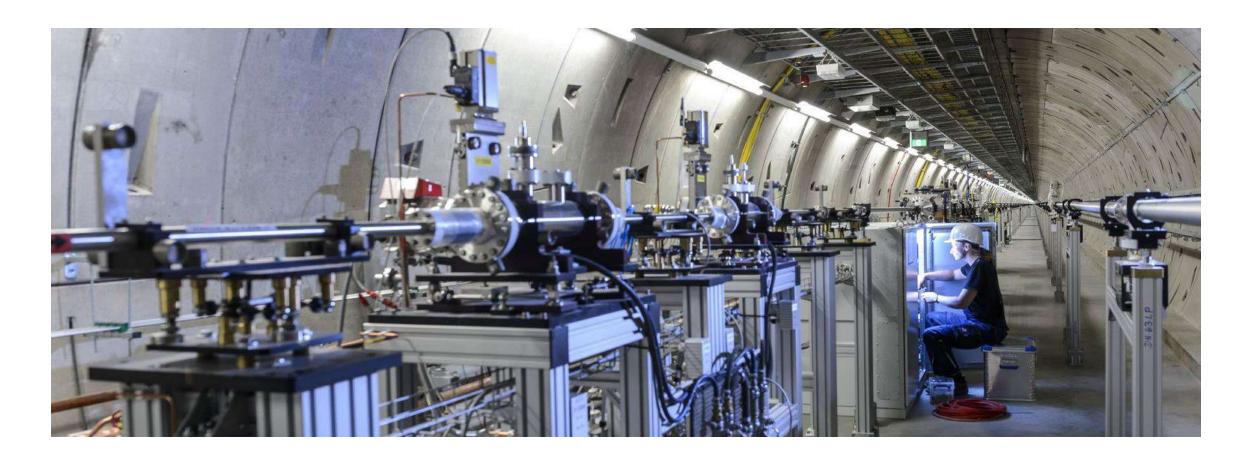


## Operation:

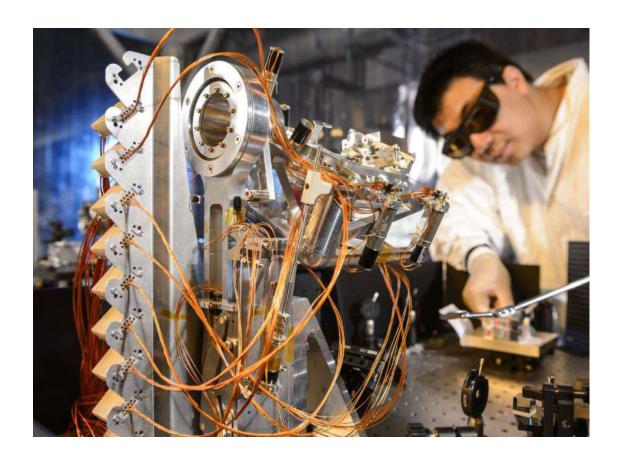
- Many single particle images
- 2. Classify for orientation
- 3. Average each class
- 4. Combine to 3D image
- 5. Reconstruct

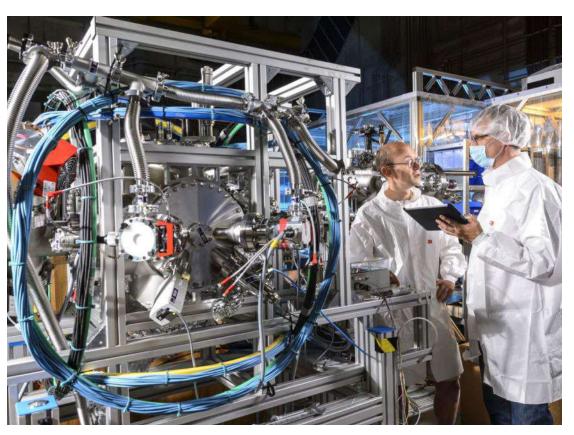


## **Photon beamlines**



# **Assembling the scientific instruments**





## Equipment control via Programmable Logic Controller (PLC) systems



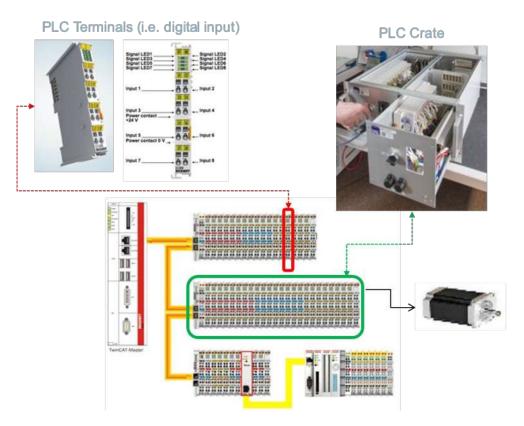


Equipment in experiment hutch (e.g. Motors, Valves, Pumps, Sensors) ~12.000 equipment operated

European XFEL



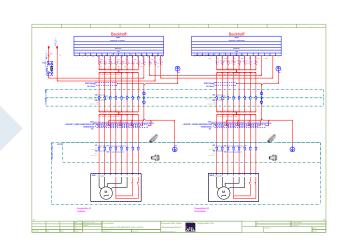
Installed PLC systems in rack room

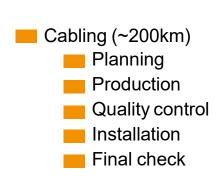


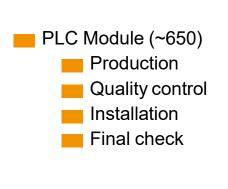
Technical concept for most installations

## From requirements to final installs





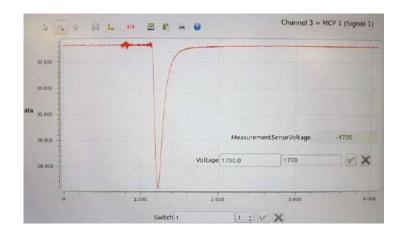




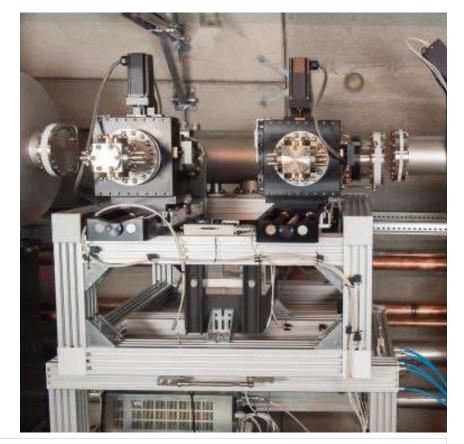
- PLC Projects / Programming
  Interlock planning
  Critical parameter definition
  PLC project generation
  Deployment
  - Deployment
    Checks
  - Commissioning

# **Selected Applications – 100MSPS Sampling Multi-Channel Plate (MCP) Based Detector**

- Includes 3 MCPs and one Photo diode
  - Motorized to adjust to beam or retract
- Invasive measurement of beam intensity



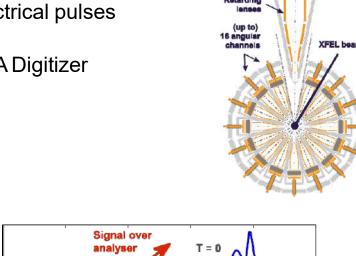


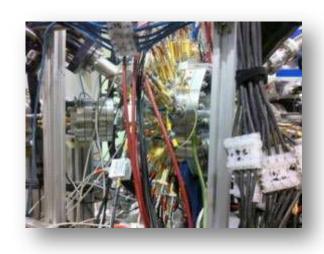


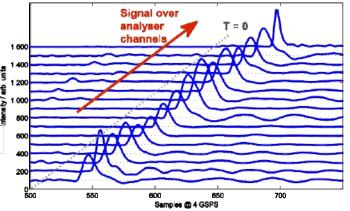
Courtesy: Photon Diagnostics (XPD) Group and collaborators

# Selected Applications – 4GSPS Sampling Photon-Electron Spectrometer (PES)

- Aggregation of 16 electron Time-of-flight tubes
- Electrons hitting the detector generate electrical pulses
- All 16 channels are digitized with MicroTCA Digitizer
  - 8 x SP Devices ADQ412-4G Module
  - 16 Channels @ 2/4GSPS @ 12bit
- Possible measurements:
  - Angle resolved energy spectrum
  - Polarization

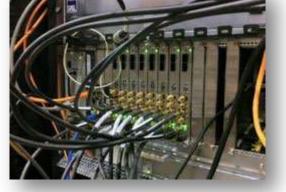








European XFEL



## **MicroTCA Standard**





MicroTCA 9U Crate



Advance Mezzanine Card (AMC) with a Rear Transition Module (RTM)

MicroTCA® is a modular, **open standard g**eared towards a more compact, less expensive systems, without cutting back on reliability or data throughput

- Created and maintained by the PCI Industrial Computer Manufacturers Group <a href="https://www.picmg.org/openstandards/microtca/">https://www.picmg.org/openstandards/microtca/</a>
  - Target Applications: Industrial control, Automation, Medical, Communication, High-Energy & Nuclear Physics among others
  - Institutes/Companies involve in the definition include DESY, SLAC, Intel, Ericsson, AMD, Pentair, etc....
- Located at the DESY campus, the **MicroTCA Technology Lab** offers a wide range of related services (hardware, training, consulting...)
  - https://techlab.desy.de/



PICMG<sup>°</sup>

## **General MicroTCA Infrastructure**





MicroTCA Crates
Large 12 slot 9U and
small 6 slot 2U
(including MCH, Power
Supply and CPU)



XFEL Timing System module for synchronization (clocks and triggers) and pulse parameters from NAT

~100 Cards

X2Timer



Required for Clock & Control system for fast 2D detectors, VETO System, Machine Protection System and photon beam loss monitors from DESY



Fast 125MSPSADC
with 10 channels and
16bit resolution for
diagnostics and
detectors from Struck
Innovative Systeme

**SIS8300** 



High-speed digitizers from 1.8GSPS to 10GSPS with 12 to 14 bit resolution from Teledyne SP Devices

ADQ412/ADQ14/ADQ7

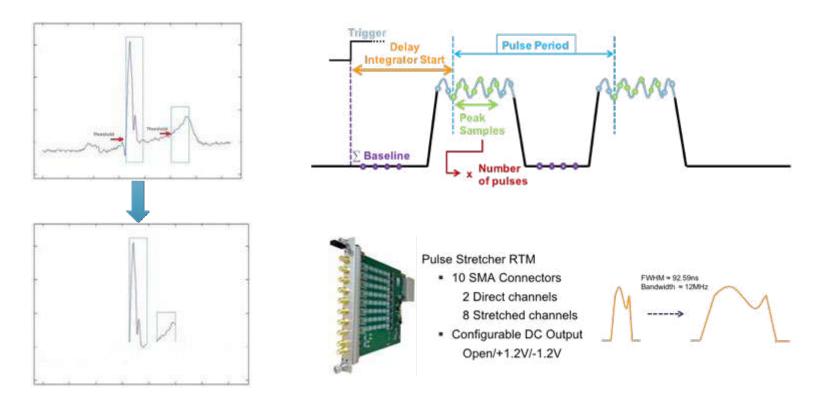
~300 Channels

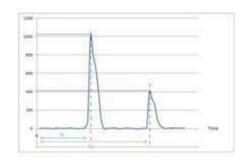
~100 Channels

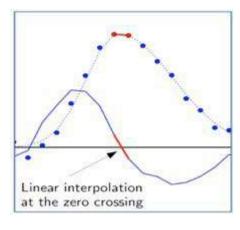
~60 Crates



## FPGA processing algorithms and interfacing standards – Signal processing







**Zero Suppression** 

**Pulse Integration** 

**Peak Time Detection** 

## **Handling Data and Complexity**

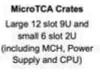
#### X-Ray Detectors at EU.XFEL Instruments



#### **Custom FPGA-based Data Producers at EU.XFEL**









X2Timer

XFEL Timing System module for synchronization (clocks and triggers) and pulse parameters from NAT



DAMC2
Required for Clock & Control system for fast 2D detectors, VETO System, Machine Protection System and photon beam loss monitors from DESY



ast 125MSPS ADC
ith 10 channels and
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diagnostics ap
stectors from
the channels and
16bit resolution for
diagnostics ap
the channels and
10GSPS with 12 to 14
bit resolution from
Teledyne SP Devices





ADQ412/ADQ14/ADQ7



## Investigation and evaluation of FPGA platforms, tool chains and machine learning

- Multiple solutions are available which use OpenCL, HLS compilers, graphical interfaces...
  - Quicker prototyping, focus on testing, easier code maintenance and easy of deployment in hardware
  - Keep in mind that custom develop for XFEL will always be necessary
- Companies provide solutions with standard interfaces that incorporated these tools/workflows
  - Not just from FPGA vendors (AMD/Intel)











Intel® High Level Synthesis Compiler

Intel® FPGA SDK for OpenCL™ Software Technology

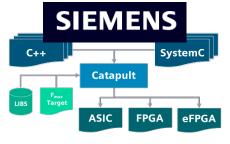


AMD

XILINX



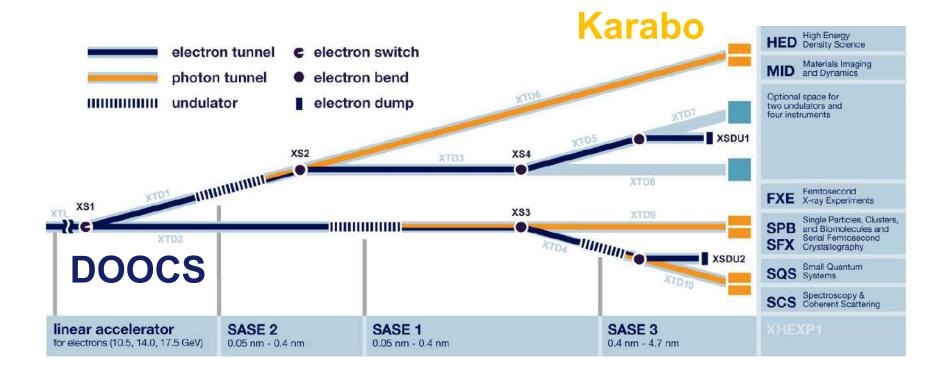






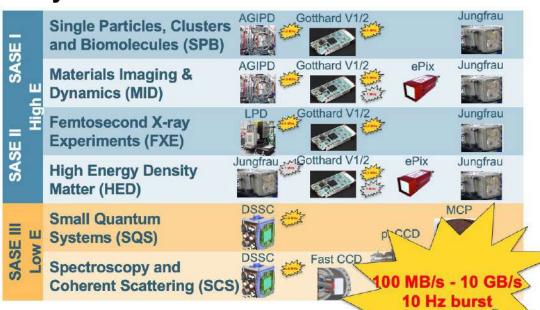


## Beamline layout and experiment stations

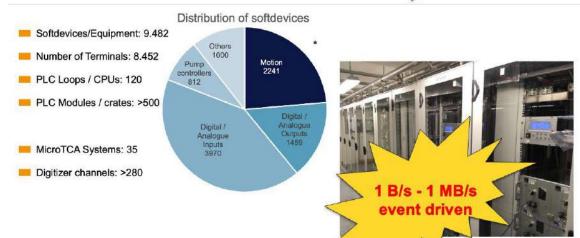


Ebreoke earb & ESELAD & afternæmdorkallenges

## **Data Drivers at the Facility X-ray Detectors**



## PLC systems and other "slow" data



## **Custom Digitizer and FPGA solution**













**MicroTCA Crates** Large 12 slot 9U and small 6 slot 2U (including MCH, Power Supply and CPU)



XFEL Timing System module for synchronization (clocks and triggers) and pulse parameters from NAT

Required for Clock & Control

system for fast 2D detectors, VETO System, Machine Protection System and photon beam loss monitors from DESY

DAMC2

#### SIS8300 ADQ412/ADQ14/ADQ7

Fast 125MSPS ADC d digitizers with 10 chartes and 16bit resolut diagnostics detec 1 MB/s - 1 GB/s Innovati 10 Hz burst

#### **Commercial Cameras**

dodel	Type	pixels	readout noise	frames/second	bits/pixel	QΕ	in vacuum	low temperature	size	size (mm2)	Add.	saturatio	78
scA1600_20gm]	CCD	2 Mp	9.4 o-	20	12	46%	по	no	4,4µm	7.2x5.4	s	8.4 kg-	0
evA1600_50gm]	CCD	2 Mp	11,6 e-	55	12	40%	Hd.	na	5.5µm	8.8×6.6	a	18.5 ke-	
ecA2440_20gm]	CMOS	5 Mp	2.3 e-	23	10/12	68%	no	по	3.45µm	8.4x7.1	9	10.4 ke-	7
acA3800_10gm)	CMOS	10 Mp	6.6 e-	10	12	46%	ng	ne	1.67µm	6.4×4.6		10.4 ke- 2.8 ke-	151
ecA1600_80gm]	CMOS	2 Mp	22,0 s-	60	12	47%	no	ne	4.5µm	7.2x5.4	G	6.8 kg-	1
acA2500_14gm]	CMOS	5 Mp	6.4 e-	14	12	67%	nα	ne	2.2µm	5.7x4.3		6.7 ke-	G
acA2040_25gm]	CMOS	4 Mp	13.8 6-	29	7	62%	no	ne	5.5pm	11.3x11.3	G	11.9 ka-	
acA720_290gm[	CMOS	VGA	6.6 e-	291	10/12	62%	na	no	8.9µm	5.0x3.7	0	21.0 kg-	
acA1920_40gm[	CMOS	2.3 Mp	6.7 e-	42	10/12	70%	no	no	5.86µm	11.3x7.1	0	31.9 kg	
scA640_120gm)	CCD	VGA	11.0 %-	120	12	1914	89	no	5.6µm	3.7x2.8	g.	16.0 kg-	
acA1300_60gm)	CMCS	1.3 Mp	24.7 e-	60	32	54%	no	ne	5.3µm	6.8x5.4	G	-	400 1
evA2300_25gm]	CCD	4 Mp	9	26	12	)P	no	по	5.5µm	12.8x9,6	0		- 100 N
auA1900_50gm)	CCD	2 Mp	11.9 e-	51	12	39%	nu	ne	5.5µm	10.6x5.9	6	10 H	iz burs
acA3088_16gm]	CMOS	6 Mp	3,2 e-	16	10/12	81%	no	no	2.4µm	7.4x6		7	_
scA2600_20gm]	CMOS	5 Mp	11.6 e-	21	10	56%	ne	no	4.8µm	12.4×9.8	G	82ke	

photo from https://www.avsupply.com/ITM/18888/AVA2300-25GM.htm

## Karabo - A SCADA Framework: Motivation

- \* 2010/11: Onsite review of control solutions at LCLS, ALBA, DIAMOND, ESRF, PSI, FLASH
  - DAQ (MHz detectors and others)
  - \* control
  - \* "slow control" logging
- \* EPICs channels were not then suited for DAQ
- \* Tango was in the middle of a concentrate on Java or C++
- \* → exflsuite → **Karabo** is a given name in southern Africa. It means "answer" in SePedi , Sesotho and Setswana

## Karabo - A SCADA Framework: Architecture

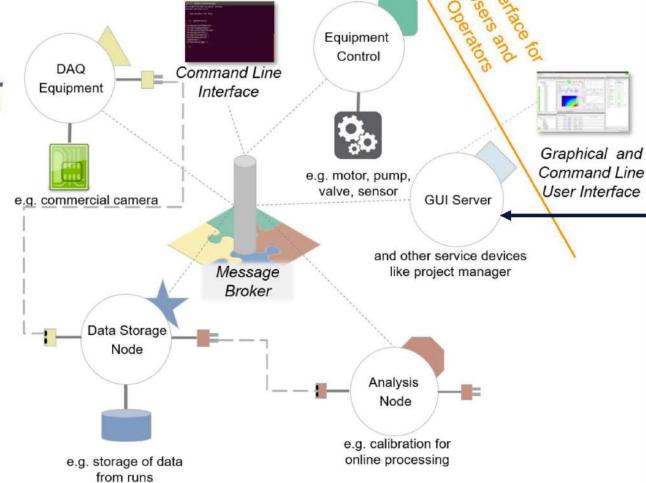
- \* pipeline (p2p) connections (scientific/large) data
  - \* Scatter/Gather/Copy/Distribute
  - \* Block/Drop on congestion
  - \* TCP
  - \* Also GUI Server GUI client
  - Capable of saturating a 10G line



- \* Gateway to the Control system
- Dynamic, discoverable topology
  - \* No central database instance

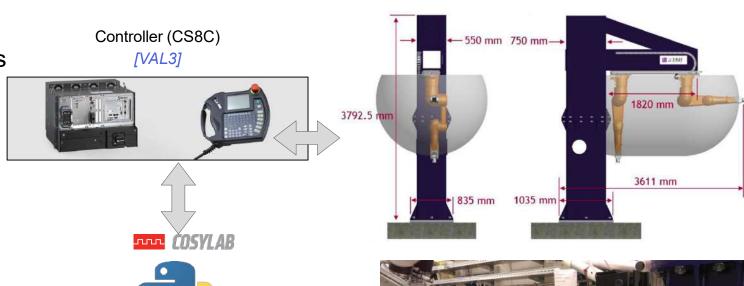






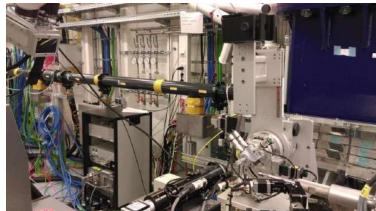
## Industry Contributions – a few existing Examples: FXE Stäubli Robot - COSYLAB

- \* Stäubli robot arm to position detectors as part of a Johann spectrometer
  - VAL3 language no in house expertise
  - \* Safe volume requirements
- COSYLAB provided async python 3 library on top of VAL3 code
- Karabo integration against COSYLAB library was done in house









## **Industry Contributions – a few existing Examples: Andor Cameras - AstroTech**

- \* Some Cameras have a windows SDK
  - \* Windows IPC interfaces to camera
  - \* Interface software written by Astrotech supports various camera models: Andor models, Shimadzu HPC
  - \* Interface to Karabo relatively generic
- Avoids the need for Windows programming in CTRL group
- Reliable interface layer that has scaled to various camera types



https://www.shimadzu.de/hyper-vision-hpv-x2



## **Technology of interest - 2022**



- **UHV vacuum chambers in Aluminum alloy**, with bi-metallic flanges, without use of welding, in the direction of the beam.
- Hard X-ray Wavefront Sensor (HXWFS) device based on the Hartmann sensor
- Interferometer solution capable of measuring the longitudinal position of a carriage (about 0,5-1,5 cm width and 3mm height) over a more than 8m-long straight line, with a required accuracy of the longitudinal position measurement is 1um
- Polycrystalline CVD diamonds (chemical vapour deposition)
- High resolution Raman confocal microscopy
- Mechanical design and delivery of optical holding systems and its large UHV chamber with manual and remote micrometric control adjustment.
- UHV compatible linear translation stages moving in the vertical/horizontal axis by a travel range of more than 2 cm till 7 cm, with a spatial movement resolution less than 0,1 um
- X-ray coatings of X-ray coatings in B4C, metals (for instance Platinum, Gold, Chromium) for mirrors and gratings (made typically by silicon)
- X-ray mirrors large about 1 m (or even more) with a substrate in Silicon single crystal <100>, Meridional radius >200 Km, surface height error <20 nm peak to valley.</p>
- Semi-customized XUV spectrometer with spectral range between 5 –200 nm, spectral resolution λ / Δλ 300-1200 and spatial resolution less than 15 μm with 3 Modes of operation Beam inspection, angularly dispersed XUV spectroscopy, focusing along non-dispersion axis.
- Laser engraving machine, table top device with a writing area that can contain a square with a size more than 120mm. The machine must be able to write on rods/tubing down to 5mm diameter.
- Cold finger with an integrated probe holder with two grooves for a temperature sensor and a hall probe.



# **Technology of interest - 2023**

- (piezo) actuators with controllers that are encoded, UHV compatible, with low magnetic permeability (< 1.01μr), few Newton force and with nanometric resolution</p>
- 50-100 pieces of compound refractive lenses made of pure beryllium
- High time resolution, 4 channel real-time oscilloscope with more than 25 GHz bandwidth, more than 70 GS/s sample rate and more than 13 Gb/s serial trigger Sensitivity is requested better than 3 mV-1 V/div.
- Linear stage that moves in horizontal direction a static load more than 2500N
- Pulse tube with compressor separated from the installation flange for low vibration application, UHV compatible, with low magnetic permeability (about 1.05μr) and able to extract more than 20W at less than 100K.

## **Campus constructions**

Plans for the other major part of the European XFEL:

- ☐ An accommodation service, the facility's 59-room Guest House were finalized and it is in operation.
- □ ...and a 940 m² building for tuning and measuring the facility's X-ray generating undulators was just finalized.
- A visitor centre, including school laboratories and an auditorium, was approved by the European XFEL Council in November 2018. It will also receive significant funding from Schleswig-Holstein.
- A building housing infrastructure for the HED instrument as well as offices for staff members and users has been finalized.

## **Outline**

- General presentation of European XFEL
- Main description of the facility
- Highlights on typical technologies in the experimental hall
- Information about procurement procedures, hints on new internal procedures
- Technologies of interest

## Typical topic of the Call for Tender - 2022



- New construction of a compressed air centre, room air and refrigeration installations
- Frame contracts for the cleaning of workwear and cleanroom clothing
- Manufacture and supply of a partial discharge measuring system
- Job ads for personnel recruitment measures, framework contract
- Framework contract for maintenance on the XFEL KTK cooling towers
- Installationsarbeiten für die Aufzugsanlage (construction)
- **■** Electrical-Earth-Cable-Connectors Infrastructure-West
- 1st construction phase of the infrastructure measures West on the Schenefeld Campus
- Installation work for the electrical engineering in the compressed air centre
- Joinery work for the new office building XHO
- Structural work for the Visitor Centre XHV
- Construction of the outdoor facilities for the connection lines to the new office building XHO
- Production and Supply of XBS-L Magnets



### **Calls for Tender 2023**

- Ballasts for discharge lamps or tubes
- DC current transformers
- Manufacture and supply of diode rectifiers
- Manufacturing and supplying 200A load switches
- Sanitary facilities XHV
- Facade for the visitor center XHV
- Heating and cooling for the visitor center
- Building automation for the visitor center XHV
- Fire alarm and voice alarm system for the visitor center XHV
- Sanitary plants for the visitor center XHV

### **Examples of current Calls For Tender**

https://www.xfel.eu/organization/procurement/calls\_for\_tender/index\_eng.html



#### **Example of a recent Call For Tender**

#### Motorized Girder for 2D Detectors at the SCS Instrument

https://ausschreibungendeutschland.de/522235 Motorized Girder for 2D Detectors at the SCS InstrumentR eferenznummer der Bekanntmachung 2019 Schenefeld

XFEL needs a detector girder that will Support different types of 2D detectors for scientific experiments in the low photon energy regime at the SCS instrument. The key functionality is the motorized, horizontal long travel distance of the main detector, referred to DSSC. This movement is enabled via a sleigh for which the remaining degrees of motion are implemented and motorized.

The detector girder consists of 5 parts

- 1- the first part is a 3 meters long stationary main module which supports the supply lines for media and cables for the detector.
- 2- The second part is a 2 meters long extension module which can be optionally installed upstream of the main module depending on the experiment configuration. In some cases, a short extension unit of the main and extension modules is needed as a third removable component.
- 3- On top of the main and the extension modules a long translation stage can be manually moved along the beam direction.
- 4- This long translation stage of about 3 meters in length has further a motorized linear stage which allows for moving the detector during experiments along the beam direction.
- 5- Finally, a fully motorized sleigh with 4 degrees of motion for fine alignment forms a generic interface to the detector housings and directly supports the main detector.

#### LEAPS & HR4tech

- LEAPS the League of European Accelerator-based Photon Sources is a strategic consortium initiated by the Directors of the Synchrotron Radiation and Free Electron Laser user facilities
- LEAPS consists of 16 organisations representing 19 light source facilities across Europe





One of the current leading LEAPS projects - **HR**<sup>4</sup>**tech –** celebrates proactive innovation and industrial exchange through fostering of industrial ecosystem within LEAPS facilities.

Join our LinkedIn group today to find out all about #LEAPStechnologynews #LEAPSprojectupdate #LEAPScallforsolution or #LEAPScallforpartnership

https://www.linkedin.com/groups/12579230/

#### Conclusion

- European XFEL is an international big science large facility
- The construction is completed but there are a lot of opportunities to collaborate on new devices
- We have organized a network of national ILOs for technology survey. Dr. Francesco d'Acapito is the Italian representative
- The national ILOs are informed by the European XFEL about:
  - Technology of interest
  - New calls for tender
  - Survey of potential suppliers for purchasing below the EU threshold limit, in the area of innovation procurement

# For any question please write to ilo@xfel.eu



#### $\equiv$

## Overview of the publicly-awarded national tender over 25k EUR- 2022

Shutterbox Version 2.0	Amphos GmbH	DE
Non-Linear Crystals	Castech Inc.	CN
Door closing system for new office building	Interflex Datensysteme GmbH	DE
CVD Diamond Attenuator	Diamond Materials GmbH	DE
payroll accounting	Lohndirekt GmbH	DE
Turbopump	Pfeiffer Vacuum GmbH	DE
Housing for Large Pixel Detektor	STFC UKRI	UK
Replacement detector head	Surface Concept GmbH	DE
Precisions Stages for Beam Splitting	SmarAct GmbH	DE
Conversion to LED lighting in experiment hall	Schubert-Nord GmbH	DE
Timing External Interface TEI; Timing Internal Interface TII	ATP Elektronik GmbH	DE
X-ray absorber CVD diamond	Diamond Materials GmbH	DE
Nitrogen (liquid and gaseous)	Linde GmbH	UK (DE)
Vacuum-insulated liquid nitrogen manual filling stations	Cryotherm GmbH & Co. KG	DE
Rental and maintenance of the liquid nitrogen plant	Linde GmbH	UK (DE)
Self-contained self-rescue device	Dräger Safety AG & Co. KGaA	DE
HPLC System for SCS	Shimadzu Deutschland GmbH	JP (DE)
Air Coils - Undulator System	RISSE electronic GmbH	DE
Diamond grating	XRnanotech GmbH	CH
Dynamic and Precise High Repetition Rate Sample Scanner	Aerotech GmbH	US (DE)







#### $\equiv$

## Overview of the publicly-awarded national tender over 25k EUR- 2022

Turbo Pumps	Pfeiffer Vacuum GmbH	DE
Ad placement - Job advertisements	AS Mediendesign	DE
Spare parts for X-Ray Scattering Imaging System	PINK GmbH	DE
Linear Motions System Spare Bellow	Hositrad Holland B.V.	NL
Stages for moving detectors	OWIS GmbH	DE
multistage roots pumps	Kashiyama Europe GmbH	JP (DE)
Stepper motor module & various parts	Beckhoff Automation GmbH & Co. KG	DE
Patsnap License extension	PatSnap (UK) Limited	UK
residual gas analyzers	MKS Instruments Deutschland GmbH	US (DE)
spare part connectors in various sizes	Lemo Elektronik GmbH	DE
Turbomolekularpumpen & Zubehör	Pfeiffer Vacuum GmbH	DE
Motorized stages	Standa UAB	LT
Turbopumps, drive electronics, accessories	Pfeiffer Vacuum GmbH	DE

Turbo Pumps	Pfeiffer Vacuum GmbH	DE
ERP - EAM Licenses and Maintenance	Intergraph PP&M Deutschland GmbH	US (DE)
Spare parts for power supplies	JEMA s.a.	BE (FR)
Herriott cell and GTI mirrors	Layertec GmbH	DE
Power supplies and frames	TDK-Lambda Germany GmbH	JP (DE)
High resolution VUV/XUV Spectrometer	Indigo Optical Systems GmbH	DE
Low noise power supplies	W-IE-NE-R, Power Electronics GmbH	US/DE







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## Overview of the publicly-awarded national tender over 25k EUR- 2022

Expansion of the compressed air system (compressor and associated control)	Kaeser Kompressoren SE	DE
Temporary employment Electronics technician Industrial engineering	Adecco Personaldienstleistungen GmbH	DE
EtherCAT IP20 equipment	Beckhoff Automation GmbH & Co. KG	DE
Support Service für ERP-System	Infor (Deutschland) GmbH	US (DE)
Special mirror for Optical Delay Line	Carl Zeiss SMT GmbH	DE
Actuators for special mirrors	Standa UAB	LT
Bayard-Alpert Pirani Combination Gauge with EtherCAT Interface	INFICON Aktiengesellschaft	CH
Pirani and Cold Cathode gauges with controller	MKS Instruments Deutschland GmbH	US (DE)
Helium bundle	Air Products GmbH	US (DE)
Achromatic delay plate made of quartz	Bernhard Halle Nachfl. GmbH	DE
Maintenance Electrical low voltage systems SASE 1, 2, 3	Schubert-Nord GmbH	DE
TruLaser Station 7000 – Laser Cutter	Trumpf Laser- und Systemtechnik GmbH	DE
vacuum system for SXP	SAES Getters S.p.A. (Avezzano Unit)	IT
Relocation, calibration and maintenance of magnetic measuring benches	Kugler GmbH	DE
AC-coupled 4-channel digitizer	Teledyne Signal Processing Devices Sweden AB	SE
High dynamic range 3rd order autocorrellator	UltraFast Innovations GmbH	DE
High quality waveplates for pump-probe laser setup	Bernhard Halle Nachfl. GmbH	DE
Dual Lock -in amplifier and Digital boxcar integrator	Zurich Instruments AG	CH
Highly reflective mirrors	Layertec GmbH	DE
A Hard X-ray Wavefront Sensor (HXWFS)	Imagine Optic S.A.	FR
Superconducting Undulator Coils	Simic S.p.A.	IT
Turbo pumps	Pfeiffer Vacuum GmbH	DE
End user training	itc. Training & Consulting GmbH	DE
Additional licenses	Infor (Deutschland) GmbH	US (DE)
Vacuum system, several vacuum valves	VAT Deutschland GmbH	CH (DE)







#### European XFEL – status and challenges

## Overview of the publicly-awarded national tender over 25k EUR- 2022 Construction

ahmenvertrag Gerüstbauarbeiten Teupe & Söhne Gerüstbau GmbH	DE
hmenvertrag Tischer-Beschlagarb. Tischlerei Stephan Kahl GmbH	DE
zentrale im XHVAC, Erweiterter Rohbau C.H. Maack GmbH & Co. KG	DE
XHO Tischlerarbeiten Die Tischler Möbelwerstätte	DE
Sauter-Cumulus GmbH, Niederlassung	
AC- Druckluftzentrale MSR-Technik Hamburg	DE
XHV Blitzschutzanlage NDB Elektrotechnik GmbH Co. KG	DE
arbeiten im Bestand (Beton Verpressarbeiten)  Berton Bautenschutz Betonservice	DE
XHO Blitzschutz D.H.W. Schultz und Sohn GmbH	DE
Erweiterung der Wartung von 2 auf 4 Jahre Caverion Deutschland GmbH	FI (DE)
XHO - Personenaufzugsanlage KONE GmbH	FI (DE)
h der Feuerlöschleitung im Medientunnel Kliewe GmbH	DE
Wämedämm- und Brandschutzarbeiten A.S. Dämmtechnik GmbH	DE
h dan Farrania ablaitung ina Madiantungal	DE
h der Feuerlöschleitung im Medientunnel  Kliewe GmbH	DE
Wämedämm- und Brandschutzarbeiten A.S. Dämmtechnik GmbH	DE
KP, Lieferung und Montage eines vermaschten ckluftsystems incl. Druckluftzentrale  PLA Pumpen und Anlagenbau GmbH	DE
XHEXP, Hallenbüro Jansen Systembau GmbH & Co. KG	DE
nvertrag für Sanitärarbeiten nach STLB Küker & Böttcher OHG	DE
XHO Fliesenarbeiten Michael Schulze Fliesen GmbH	DE
XHO, MSR-Technik Sauter-Cumulus GmbH	CH (DE)
vertrag über Maler- und Lackierarbeiten Axel Stiboy Malereibetrieb GmbH	DE
E3 SXP, Techische Gase Druckluft Dräger Medical ANSY GmbH	DE
Neubau XHO, Putzarbeiten CC Putz GmbH	DE
West, Lieferung Montage Trafo, Schaltanalgen  WISAG Elektrotechnik Nord GmbH & Co.  KG	DE







## Overview of the publicly-awarded national tender over 25k EUR- 2022 Construction







## **Awarded calls for tender 2022**



<u>Document</u> number	Description	Contracting authority	Publication date	Company	Compan Y country
<u>546237-2022</u>	Germany-Schenefeld: Excavating and earthmoving work/ die Erdarbeiten zu der Baumaßnahme XHV Type of procedure: Open procedure	European XFEL	07.10.2022	Groth & Co. Bauunternehmung GmbH	Germany
443737-2022	Germany-Schenefeld: Personnel and payroll services Type of procedure: Open procedure	European XFEL	12.08.2022	AS Mediendesign	Germany
<u>441587-2022</u>	Germany-Schenefeld: Miscellaneous furniture and equipment/ Realisierung der Planung, also die Herstellung der Ausstellung (inkl. Ausstellungs- und Möbelbau) XHV Type of procedure: Competitive procedure with negotiation	European XFEL	12.08.2022	Archimedes Exhibitions GmbH	Germany
<u>271435-2022</u>	Germany-Hamburg: Analysis services/Probenahme und Analyse von Kühlwasser aus Rückkühlwerken Type of procedure: Open procedure	DESY	20.05.2022	SGS Institut Fresenius GmbH	Germany
<u>253930-2022</u>	Germany-Schenefeld: Laboratory, optical and precision equipment (excl. glasses)/Superconducting undulator afterburner PRE-SerieS prOtotype (S-PRESSO)  Type of procedure: Negotiated procedure without a call for competition	European XFEL	13.05.2022	Bilfinger Noell GmbH	Germany
<u>217961-2022</u>	Germany-Schenefeld: Time accounting or human resources software package  Type of procedure: Competitive procedure with negotiation	European XFEL	26.04.2022	LÜTH & DÜMCHEN Automatisierungsprojekt GmbH	Germany
217958-2022	Germany-Schenefeld: Time accounting or human resources software package Type of procedure: Competitive procedure with negotiation	European XFEL	26.04.2022	HR4YOU AG	Germany

#### **Awarded calls for tender 2022**



<u>Document</u> <u>number</u>	Description	Contracting authority	Publication date	Company	Company country
<u>24654-2022</u>	Germany-Schenefeld: Engineering design services for mechanical and electrical installations for buildings/Planung der Technischen Ausrüstung für das Visitor and Conference Center Type of procedure: Open procedure	European XFEL	17.01.2022	Pinck Ingenieure Consulting GmbH & Co. KG	Germany
<u>17194-2022</u>	Germany-Schenefeld: Fire-alarm system installation work/ Neubau Bürogebäude XHO - Brandmeldeanlage Type of procedure: Open procedure	European XFEL	14.01.2022	Alarm- und Sicherheitstechnik B.W. GmbH	Germany
<u>16111-2022</u>	Germany-Schenefeld: Supervision of building work/uüberwachung (LPh 8) für die Technische Ausrüstung für den Neubau des Bürogebäudes XHO Type of procedure: Open procedure	European XFEL	12.01.2022	Pinck Ingenieure Consulting GmbH & Co. KG	Germany
606019-2022	Germany-Schenefeld: Structural shell work/Neubau Visitor Center XHV, Rohbauarbeiten Type of procedure: Open	European XFEL	02.11.2022	Meier Hoch-/Tiefbau GmbH	Germany
601993-2022	Germany-Schenefeld: Cameras/Ultrafast speed camera with a Megahertz Rate Sampling for MHZ microscopy Type of procedure: Negotiated without prior call for competition	European XFEL	31.10.2022	Shimadzu Deutschland GmbH	Germany
<u>581902-2022</u>	Germany-Schenefeld: Payroll management services Type of procedure: Open	European XFEL	21.10.2022	Lohndirekt GmbH	Germany
20524-2022	Germany-Schenefeld: Caretaker services Type of procedure: Restricted procedure	European XFEL	14.01.2022	x	х
17294-2022	Germany-Schenefeld: Switching station installation work/Neubau Bürogebäude XHO - Erstellung der Mess-, Steuerungs- und Regelungstechnik Type of procedure: Open procedure	European XFEL	14.01.222	x	x

## Thank you for your attention

